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POSITION DETECTION DEVICE

Abstract

A position detection device that detects a position of a detection body includes a signal processing unit that calculates a detection body position. The signal processing unit corrects a first signal and a second signal different in phase from the first signal, calculates a pre-correction position of the detection body based on the first and second signals, calculates a correction function based on an error of the pre-correction position, and corrects the pre-correction position using the correction function. The signal processing unit corrects the first signal and the second signal based on cases where a gap between an arrangement unit and the detection body is at a reference gap, one or different near gaps, and one or different far gaps. The signal processing unit derives a correction value used in the correction function for each of sections of a detection range.

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Background/Summary

CROSS REFERENCE TO RELATED APPLICATIONS [0001] The present application is a continuation application of International Patent Application No. PCT/JP2023/037549 filed on Oct. 17, 2023, which designated the U.S. and claims the benefit of priority from Japanese Patent Application No. 2022-183453 filed on Nov. 16, 2022, and Japanese Patent Application No. 2023-166407 filed on Sep. 27, 2023. The disclosures of all the above applications are incorporated herein.

TECHNICAL FIELD
[0002] The present disclosure relates to a position detection device.
BACKGROUND ART
[0003] In the related art, a linear position sensor detects a position of a detection body based on a change in a magnetic field received from multiple magnets disposed on the detection body.
SUMMARY
[0004] According to an aspect of the present disclosure, a position detection device for detecting a position of a detection body. The position detection device includes a signal output unit, an arrangement unit and a signal processing unit. The signal output unit is configured to output a first signal having a sine wave shape corresponding to a position of the detection body, and a second signal different in phase from the first signal and having a cosine wave shape corresponding to the position of the detection body. The arrangement unit is provided with the signal output unit and faces the detection body in a state of being spaced apart from the detection body. The signal processing unit is configured to calculate, based on the first signal and the second signal, a detection body position which is a position of the detection body when the detection body is displaced in a predetermined detection range. The signal processing unit is configured to correct the first signal and the second signal. The signal processing unit is configured to calculate a pre-correction detection body position based on the corrected first signal and second signal. The pre-correction detection body position is the detection body position before correction. The signal processing unit is configured to calculate a correction function based on an error of the calculated pre-correction detection body position. The signal processing unit is configured to correct the pre-correction detection body position calculated for each of sections of the detection range using the correction function.

Description

BRIEF DESCRIPTION OF DRAWINGS
[0005] The details of one or more embodiments are set forth in the accompanying drawings and the description below. Other features and advantages will be apparent from the description and drawings, and from the claims.
[0006] FIG. **1** is a schematic configuration diagram of a position detection device according to a first embodiment.
[0007] FIG. **2** is a cross-sectional view taken along a line II-II in FIG. **1**.
[0008] FIG. **3** is a cross-sectional view taken along a line III-III in FIG. **1**.

[0009] FIG. **4** is a diagram showing a substrate according to the first embodiment.

[0010] FIG. **5** is a block diagram of the position detection device according to the first embodiment.

[0011] FIG. **6** is a diagram showing an example of a waveform of a first voltage value generated in a first reception coil and a waveform of a second voltage value generated in a second reception coil according to the first embodiment.

[0012] FIG. **7** is a diagram showing details of an angle calculation unit in the block diagram of the position detection device according to the first embodiment.

[0013] FIG. **8** is a diagram showing an example of a waveform of a first voltage value generated in an ideal first reception coil and a waveform of a second voltage value generated in an ideal second reception coil.

[0014] FIG. **9** is a diagram showing a relative relationship between a mechanical angle and an electric angle.

[0015] FIG. **10** is a diagram showing an example of an error of a rotation angle.

[0016] FIG. **11** is a diagram showing an example of an error of the rotation angle before correction calculated by a position calculation unit according to the first embodiment.

[0017] FIG. **12** is a diagram showing that offsets of a first conversion signal and a second conversion signal changes according to a gap.

[0018] FIG. **13** is a diagram showing an example of an error of a correction rotation angle corrected by a section correction unit according to the first embodiment.

[0019] FIG. **14** is a block diagram of the position detection device according to the first embodiment.

[0020] FIG. **15** is a diagram showing a substrate according to a second embodiment.

[0021] FIG. **16** is a diagram showing a rotation member according to the second embodiment.

[0022] FIG. **17** is a diagram showing a position detection device and a detection body according to a third embodiment.

[0023] FIG. **18** is a block diagram of the position detection device according to the third embodiment.

[0024] FIG. **19** is a diagram showing an example of an error of a rotation angle calculated by a position calculation unit according to a fourth embodiment.

[0025] FIG. **20** is a diagram showing an example of an error of a correction rotation angle corrected by a section correction unit according to the fourth embodiment.

[0026] FIG. **21** is a diagram showing a substrate according to a fifth embodiment.

DETAILED DESCRIPTION

[0027] In a comparative example, a linear position sensor detects a position of a detection body based on a change in a magnetic field received from multiple magnets disposed on the detection body. The linear position sensor includes a detection unit that acquires a sine signal and a cosine signal of a phase corresponding to positions of the multiple magnets in the moving detection body, and detects a position of the detection body based on the sine signal and the cosine signal acquired by the detection unit.

[0028] In the linear position sensor, detection accuracy of a specific position is improved by disposing the multiple magnets in the detection body at irregular intervals or disposing the magnets at irregular heights to adjust the magnetic field received by the detection unit to be unbalanced.

[0029] Intensive studies by the inventors have found that detection accuracy can be improved in a position detection device, like the linear position sensor of the comparative example, which detects the position of a detection body based on sine and cosine signals, without being limited to a specific position.

[0030] In contrast, according to the present disclosure, a position detection device can improve detection accuracy.

[0031] According to an aspect of the present disclosure, a position detection device for detecting a

position of a detection body. The position detection device includes a signal output unit, an arrangement unit and a signal processing unit. The signal output unit is configured to output a first signal having a sine wave shape corresponding to a position of the detection body, and a second signal different in phase from the first signal and having a cosine wave shape corresponding to the position of the detection body. The arrangement unit is provided with the signal output unit and faces the detection body in a state of being spaced apart from the detection body. The signal processing unit is configured to calculate, based on the first signal and the second signal, a detection body position which is a position of the detection body when the detection body is displaced in a predetermined detection range. The signal processing unit is configured to correct the first signal and the second signal. The signal processing unit is configured to calculate a pre-correction detection body position based on the corrected first signal and second signal. The pre-correction detection body position is the detection body position before correction. The signal processing unit is configured to calculate a correction function based on an error of the calculated pre-correction detection body position. The signal processing unit is configured to correct the pre-correction detection body position calculated for each of sections of the detection range using the correction function. An interval between the detection body and the arrangement unit in a facing direction in which the detection body and the arrangement unit face each other is defined as a gap. The gap that serves as a reference is defined as a reference gap. The gap smaller than the reference gap is defined as a near gap. The gap larger than the reference gap is defined as a far gap. The signal processing unit is configured to correct the first signal and the second signal such that each of errors of the pre-correction detection body position approach 0, the errors including errors occurring when the gap is at the reference gap, one or different near gaps, and one or different far gaps. The signal processing unit is configured to derive a correction value used in the correction function for each of the sections.

[0032] According to another aspect of the present disclosure, a position detection device for detecting a position of a detection body. The position detection device includes a signal output unit, an arrangement unit and a signal processing unit. The signal output unit is configured to output a first signal having a sine wave shape corresponding to a position of the detection body, and a second signal different in phase from the first signal and having a cosine wave shape corresponding to the position of the detection body. The arrangement unit is provided with the signal output unit and faces the detection body in a state of being spaced apart from the detection body. The signal processing unit is configured to calculate, based on the first signal and the second signal, a detection body position which is a position of the detection body when the detection body is displaced in a predetermined detection range. The signal processing unit includes a signal correction unit, a position calculation unit, and a section correction unit. The signal correction unit is configured to correct the first signal and the second signal. The position calculation unit is configured to calculate a pre-correction detection body position based on the first signal and the second signal corrected by the signal correction unit. The pre-correction detection body position is the detection body position before correction. The section correction unit is configured to calculate a correction function based on an error of the pre-correction detection body position calculated by the position calculation unit. The section correction unit is configured to correct the pre-correction detection body position calculated by the position calculation unit for each of sections of the detection range using the correction function. An interval between the detection body and the arrangement unit in a facing direction in which the detection body and the arrangement unit face each other is defined as a gap. The gap that serves as a reference is defined as a reference gap. The gap smaller than the reference gap is defined as a near gap. The gap larger than the reference gap is defined as a far gap. The signal correction unit is configured to correct the first signal and the second signal such that each of errors of the pre-correction detection body position approach 0, the errors including errors occurring when the gap is at the reference gap, one or different near gaps, and one or different far gaps. The section correction unit is configured to derive a correction value

used in the correction function for each of the sections.

[0033] According to this, it is possible to reduce a detection error by deriving a correction term such that an error of the detection body position approaches 0 when the interval between the detection body and the arrangement unit is any one of the reference gap, the near gap, and the far gap. Accordingly, the detection accuracy of the position detection device can be improved.

[0034] Hereinafter, embodiments of the present disclosure will be described with reference to the drawings. In the following embodiments, the same or equivalent parts as those described in the preceding embodiments are denoted by the same reference numerals, and the description thereof may be omitted. When only a part of components is described in the embodiment, components described in the preceding embodiments can be applied to other parts of the components. In the following embodiments, the embodiments can be partially combined with each other as long as the embodiments do not cause any trouble in combination, even if the combination is not specified in particular.

First Embodiment

[0035] The present embodiment will be described with reference to FIGS. **1** to **12**. In the present embodiment, an example in which a position detection device **1** is used to detect a rotation position of a brake pedal or an accelerator pedal of a vehicle pedal device will be described. In the following description, the brake pedal or the accelerator pedal may be simply referred to as a pedal.

[0036] As shown in FIGS. **1** to **3**, the position detection device **1** according to the present embodiment includes a rotation member **20** and a substrate **30**. A rotation shaft center CL displayed in FIGS. **1** to **3** is a rotation center of a rotation shaft **70** and the rotation member **20** of the pedal. In the present embodiment, a direction in which the rotation shaft center CL extends is defined as an axial direction Da, a direction radially extending about an axis of the rotation shaft center CL is defined as a radial direction Dr, and a rotation direction of the rotation shaft center CL is defined as a circumferential direction Dc. The axial direction Da, the radial direction Dr, and the circumferential direction Dc are directions intersecting one another, strictly speaking, directions perpendicular to one another.

[0037] The rotation member **20** is made of metal and is formed in a flat plate shape having a thickness in the axial direction Da. The rotation member **20** is coupled to the rotation shaft **70** of the pedal to be non-rotatable relative to the rotation shaft **70**. For example, the rotation member **20** may be non-rotatable relative to the rotation shaft **70** via a locking key member, or may be non-rotatable relative to the rotation shaft **70** by being welded to the rotation shaft **70**.

[0038] The rotation member **20** is a rotation body supported by a non-rotation member via the rotation shaft **70** to be rotatable about the predetermined rotation shaft center CL, and rotates integrally with the pedal and the rotation shaft **70**. Accordingly, the position detection device **1** is capable of detecting the rotation position of the pedal by detecting a rotation position of the rotation member **20**. That is, a rotation position of the rotation shaft **70** is also the rotation position of the pedal, and is also the rotation position of the rotation member **20** as the detection body. The position detection device **1** according to the present embodiment detects the rotation position of the pedal by detecting the rotation position of the rotation member **20**.

[0039] The rotation member **20** is coupled to the rotation shaft **70** of the pedal, and thus the rotation member **20** reciprocates according to a stepping-on operation of the pedal within a predetermined angle range about the rotation shaft center CL, but does not complete one complete rotation about the rotation shaft center CL. For example, the rotation member **20** according to the present embodiment reciprocates within an angle range of 0° to 24°, which is a range smaller than 0° to 360° about the rotation shaft center CL, by the stepping-on operation of the pedal. In FIG. **1**, a part of an outer shape of four targets **22**, **23**, **24**, and **25** of the rotation member **20** at end positions in the reciprocating movement is shown by a two-dot chain line.

[0040] As shown in FIG. **1**, the rotation member **20** includes a coupling portion **21** and the four targets **22**, **23**, **24**, and **25**. That is, the four targets **22**, **23**, **24**, and **25** provided in the rotation

member **20** rotate integrally about the rotation shaft center CL. According to the stepping-on operation of the pedal, the four targets **22**, **23**, **24**, and **25** all reciprocate in the circumferential direction Dc.

[0041] For example, the rotation member **20** is formed as a single component including the coupling portion **21** and the four targets **22**, **23**, **24**, and **25**. The rotation member **20** is formed in a flat plate shape having a uniform thickness in the axial direction Da. Therefore, the thicknesses of the four targets **22** to **25** in the axial direction Da are the same. In the description of the present embodiment, the four targets **22**, **23**, **24**, and **25** may be collectively referred to as four targets **22** to **25**. The four targets **22** to **25** may be referred to as a first target **22**, a second target **23**, a third target **24**, and a fourth target **25**, respectively.

[0042] The coupling portion **21** is disposed in a center portion of the rotation member **20** and has an annular shape centered on the rotation shaft center CL. A fitting hole **21**a penetrating the coupling portion **21** in the axial direction Da is provided on an inner side of the coupling portion **21**. The rotation shaft **70** is fitted into the fitting hole **21**a to be non-rotatable relative to the coupling portion **21**. That is, the rotation member **20** is coupled to the rotation shaft **70** at the coupling portion **21**.

[0043] The four targets **22** to **25** are each provided to protrude outward in the radial direction Dr from the coupling portion **21**. The four targets **22** to **25** are arranged at equal pitches in the circumferential direction Dc. Specifically, the first target **22**, the second target **23**, the third target **24**, and the fourth target **25** are arranged in this order at pitch intervals of 90 degrees in the circumferential direction Dc. The interval in the circumferential direction Dc of the four targets **22** to **25** is set to be able to cover one of a first positive spiral portion **32**a and a first reverse spiral portion **32**b, which will be described later, of a first reception coil **32**. The interval in the circumferential direction Dc of the four targets **22** to **25** is set to be able to cover one of a second positive spiral portion **33**a and a second reverse spiral portion **33**b, which will be described later, of a second reception coil **33** simultaneously with one of the first positive spiral portion **32**a and the first reverse spiral portion **32**b.

[0044] The first target **22** is disposed on a side opposite to the third target **24** with the rotation shaft center CL sandwiched therebetween. The second target **23** is disposed on a side opposite to the fourth target **25** with the rotation shaft center CL sandwiched therebetween. When viewed in a direction along the axial direction Da, the four targets **22** to **25** are disposed to be point symmetric about the rotation shaft center CL as a whole.

[0045] As shown in FIG. **3**, the first target **22** is provided on one side in the axial direction Da and has a first facing surface **22**a facing the substrate **30**. As shown in FIG. **2**, the second target **23** is provided on one side in the axial direction Da and has a second facing surface **23**a facing the substrate **30**. The third target **24** is provided on one side in the axial direction Da and has a third facing surface **24**a facing the substrate **30**. The fourth target **25** is provided on one side in the axial direction Da and has a fourth facing surface **25**a facing the substrate **30**. The first facing surface **22**a, the second facing surface **23**a, the third facing surface **24**a, and the fourth facing surface **25**a are provided parallel to the other surface **30**b, which will be described later, of the substrate **30**.

[0046] As shown in FIG. **1**, a size of the first target **22** in the circumferential direction Dc decreases toward the outside in the radial direction Dr from an innermost portion in the radial direction Dr to a substantially center portion in the radial direction Dr. The size of the first target **22** in the circumferential direction Dc increases toward the outside in the radial direction Dr from the substantially center portion in the radial direction Dr to an outermost portion in the radial direction Dr. Accordingly, an end portion on the one side and an end portion on the other side in the circumferential direction Dc of the first target **22** extend in a curved shape when viewed in the direction along the axial direction Da.

[0047] The second target **23**, the third target **24**, and the fourth target **25** have the same shape as the first target **22**. In the present embodiment, all of the four targets **22** to **25** have the same shape.

[0048] Accordingly, an end portion on the one side and an end portion on the other side in the circumferential direction Dc of the second target **23** extend in a curved shape when viewed in the direction along the axial direction Da. An end portion on the one side and an end portion on the other side in the circumferential direction Dc of the third target **24** extend in a curved shape when viewed in the direction along the axial direction Da. An end portion on the one side and an end portion on the other side in the circumferential direction Dc of the fourth target **25** extend in a curved shape when viewed in the direction along the axial direction Da.

[0049] In the present embodiment, all of the four targets **22** to **25** have the same shape and rotate integrally as described above. Therefore, operation ranges of the four targets **22** to **25** have the same length in the circumferential direction Dc. The operation range of the first target **22** is defined as a first operation range W**1**, the operation range of the second target **23** is defined as a second operation range W**2**, the operation range of the third target **24** is defined as a third operation range W**3**, and the operation range of the fourth target **25** is defined as a fourth operation range W**4**.

[0050] The first operation range W**1** is a maximum range in the circumferential direction Dc on which the first target **22** extends according to the reciprocating movement of the first target **22**. Therefore, the first target **22** reciprocates in the circumferential direction Dc within the first operation range W**1**. The second operation range W**2** is a maximum range in the circumferential direction Dc on which the second target **23** extends according to the reciprocating movement of the second target **23**. Therefore, the second target **23** reciprocates in the circumferential direction Dc within the second operation range W**2**. The third operation range W**3** is a maximum range in the circumferential direction Dc on which the third target **24** extends according to the reciprocating movement of the third target **24**. Therefore, the third target **24** reciprocates in the circumferential direction Dc within the third operation range W**3**. The fourth operation range W**4** is a maximum range in the circumferential direction Dc on which the fourth target **25** extends according to the reciprocating movement of the fourth target **25**. Therefore, the fourth target **25** reciprocates in the circumferential direction Dc in the fourth operation range W**4**.

[0051] The substrate **30** is a multilayer printed substrate on which wiring patterns are provided and electrical components (not shown) are mounted. Specifically, the substrate **30** is a multilayer substrate in which an insulating film and a wiring layer are alternately laminated. Although not particularly shown, various electronic components such as resistors are appropriately disposed in the substrate **30**.

[0052] The substrate **30** has a planar one surface **30**a and the other surface **30**b that are orthogonal to the axial direction Da. That is, a normal direction of the substrate **30** coincides with the axial direction Da. The one surface **30**a of the substrate **30** is provided on one side of the substrate **30** in the axial direction Da. The other surface **30**b of the substrate **30** is provided on the other side of the substrate **30** opposite to the one side in the axial direction Da.

[0053] The substrate **30** is a non-rotation member that does not rotate relative to the pedal. Accordingly, the rotation member **20** rotates relative to the substrate **30**.

[0054] The substrate **30** is disposed on the one side in the axial direction Da with respect to the four targets **22** to **25**. The other surface **30**b of the substrate **30** faces the first facing surface **22**a, the second facing surface **23**a, the third facing surface **24**a, and the fourth facing surface **25**a of the four targets **22** to **25** at predetermined intervals in the axial direction Da. In other words, the substrate **30** faces the rotation member **20** in a state of being separated from the rotation member **20** in a facing direction which is a direction facing the rotation member **20**. A predetermined interval in the axial direction Da between the substrate **30** and the rotation member **20** is the same as a size between the substrate **30** and the four targets **22** to **25**. Hereinafter, the predetermined interval in the axial direction Da between the substrate **30** and the rotation member **20** is also referred to as a gap G.

[0055] The substrate **30** is formed in a disc shape centered on the rotation shaft center CL. A through hole **30**c penetrating the substrate **30** in the axial direction Da is provided in a center of the

substrate **30**. The rotation shaft **70** is inserted into the through hole **30***c*.

[0056] As shown in FIGS. **1**, **4**, and **5**, the substrate **30** includes one transmission coil **31**, eight first reception coils **32**, eight second reception coils **33**, and a signal processing circuit **40** described later, which are provided as wiring patterns. The one transmission coil **31** provided in the position detection device **1**, the eight first reception coils **32**, the eight second reception coils **33**, and the signal processing circuit **40** described later are provided in a single substrate **30**. The one transmission coil **31**, the eight first reception coils **32**, and the eight second reception coils **33** are provided in the wiring layer provided in each layer of the multilayer substrate. The transmission coil **31**, the eight first reception coils **32**, and the eight second reception coils **33** provided in each layer are appropriately coupled via a via **34**.

[0057] The one transmission coil **31**, the eight first reception coils **32**, and the eight second reception coils **33** are coupled to the signal processing circuit **40** described later, which is formed by an IC and the like mounted on the substrate **30**, via a coupling wiring pattern (not shown). The substrate **30** corresponds to an arrangement unit in which the one transmission coil **31**, the eight first reception coils **32**, the eight second reception coils **33**, and the signal processing circuit **40** are disposed.

[0058] The transmission coil **31** is wound multiple times and formed in an annular shape. The transmission coil **31** is provided to surround the eight first reception coils **32** and the eight second reception coils **33** provided in the substrate **30** when viewed in the direction along the axial direction Da. In other words, when viewed in the direction along the axial direction Da, the transmission coil **31** is disposed outside the eight first reception coils **32** and the eight second reception coils **33**. The eight first reception coils **32** and the eight second reception coils **33** are alternately arranged in the circumferential direction Dc inside the transmission coil **31**.

[0059] As shown in FIG. **4**, the eight first reception coils **32** and the eight second reception coils **33** according to the present embodiment mainly have a spiral shape. Each of the eight first reception coils **32** includes the first positive spiral portion **32***a* and the first reverse spiral portion **32***b*. The first positive spiral portion **32***a* and the first reverse spiral portion **32***b* are portions forming a spiral shape in each of the eight first reception coils **32**. The first positive spiral portion **32***a* and the first reverse spiral portion **32***b* of each of the eight first reception coils **32** face one of the four targets **22** to **25** in the axial direction Da. The eight first reception coils **32** are electrically coupled to each other by one stroke writing via the first positive spiral portions **32***a* and the first reverse spiral portions **32***b*.

[0060] Each of the eight second reception coils **33** according to the present embodiment includes the second positive spiral portion **33***a* and the second reverse spiral portion **33***b*. The second positive spiral portion **33***a* and the second reverse spiral portion **33***b* are portions forming a spiral shape in each of the eight second reception coils **33**. The second positive spiral portion **33***a* and the second reverse spiral portion **33***b* of each of the eight second reception coils **33** face one of the four targets **22** to **25** in the axial direction Da. The eight second reception coils **33** are electrically coupled to each other by one stroke writing via the second positive spiral portions **33***a* and the second reverse spiral portions **33***b*.

[0061] The first positive spiral portion **32***a* and the first reverse spiral portion **32***b* of each of the eight first reception coils **32** have the same shape. Therefore, in the following, only the first reception coil **32** facing the target **22** will be described in detail, and the detailed description of the first reception coils **32** facing the remaining three targets **23** to **25** will be omitted.

[0062] The second positive spiral portion **33***a* and the second reverse spiral portion **33***b* of each of the eight second reception coils **33** have the same shape. Therefore, in the following, only the second reception coil **33** facing the target **22** will be described in detail, and the detailed description of the second reception coils **33** facing the remaining three targets **23** to **25** will be omitted.

[0063] The first positive spiral portion **32***a* and the first reverse spiral portion **32***b* of the first reception coil **32** and the second positive spiral portion **33***a* and the second reverse spiral portion

33*b* of the second reception coil **33** are provided side by side at predetermined intervals along the circumferential direction Dc. Specifically, the first positive spiral portion **32***a*, the second positive spiral portion **33***a*, the first reverse spiral portion **32***b*, and the second reverse spiral portion **33***b* are provided side by side in this order from one side to the other side of the substrate **30** in the circumferential direction Dc.

[0064] The first positive spiral portion **32***a* and the first reverse spiral portion **32***b* have a spiral pattern shape formed to draw a square shape while changing a diameter. Coils of the first positive spiral portions **32***a* and the first reverse spiral portions **32***b* are respectively wound in the same direction multiple times in the multiple wiring layers of the substrate **30**. The first positive spiral portions **32***a* and the first reverse spiral portions **32***b* respectively provided in the multiple wiring layers of the substrate **30** are provided to overlap each other in the normal direction. However, winding directions (that is, spiral directions) of the coils of the first positive spiral portion **32***a* and the first reverse spiral portion **32***b* are opposite to each other. For example, the winding direction of the coil of the first positive spiral portion **32***a* is clockwise when viewed in the normal direction. On the other hand, the winding direction of the coil of the first reverse spiral portion **32***b* is counterclockwise when viewed in the normal direction.

[0065] Similarly to the first positive spiral portion **32***a* and the first reverse spiral portion **32***b*, the second positive spiral portion **33***a* and the second reverse spiral portion **33***b* have a spiral pattern shape formed to draw a square shape while changing a diameter. Similarly to the first positive spiral portion **32***a* and the first reverse spiral portion **32***b*, the coils of the second positive spiral portion **33***a* and the second reverse spiral portion **33***b* are respectively wound in the same direction multiple times in the multiple wiring layers of the substrate **30**. The second positive spiral portions **33***a* and the second reverse spiral portions **33***b* respectively provided in the multiple wiring layers of the substrate **30** are provided to overlap each other in the normal direction. However, spiral directions of the second positive spiral portion **33***a* and the second reverse spiral portion **33***b* are opposite to each other. For example, the coil of the second positive spiral portion **33***a* is wound clockwise. On the other hand, the coil of the second reverse spiral portion **33***b* is wound counterclockwise.

[0066] Among the eight first reception coils **32** and the eight second reception coils **33**, the first reception coil **32** and the second reception coil **33** facing the first target **22** are coils for detecting a position of the first target **22** in the circumferential direction Dc.

[0067] The first positive spiral portion **32***a* and the first reverse spiral portion **32***b* of the first reception coil **32** are disposed such that at least a part of the first positive spiral portion **32***a* and the first reverse spiral portion **32***b* overlap the one side of the first target **22** in the axial direction Da at any position within the first operation range W**1** of the first target **22**. The second positive spiral portion **33***a* and the second reverse spiral portion **33***b* of the second reception coil **33** are disposed such that at least a part of the second positive spiral portion **33***a* and the second reverse spiral portion **33***b* overlap the one side of the first target **22** in the axial direction Da at any position within the first operation range W**1** of the first target **22**.

[0068] Therefore, among the eight first reception coils **32** and the eight second reception coils **33**, the first reception coil **32** and the second reception coil **33** facing the first target **22** output detection signals corresponding to the position of the first target **22**. The first reception coil **32** and the second reception coil **33** facing the first target **22** function as a signal output unit that outputs a signal corresponding to the rotation position of the rotation member **20**.

[0069] The detection signals output by the first reception coil **32** and the second reception coil **33** are, for example, voltage values. The detection signal output by the first reception coil **32** is a first signal output by the first reception coil **32** as a signal output unit, and corresponds to, for example, a first voltage value V**1** shown in FIG. **5** described later. The detection signal output by the second reception coil **33** is a second signal output by the second reception coil **33** functioning as a signal output unit, and corresponds to, for example, a second voltage value V**2** shown in FIG. **5** described

later.

[0070] The first reception coil **32** and the second reception coil **33** facing the second target **23** are coils for detecting a position of the second target **23** in the circumferential direction Dc. Therefore, the first reception coil **32** and the second reception coil **33** facing the second target **23** output detection signals corresponding to the position of the second target **23**.

[0071] The first reception coil **32** and the second reception coil **33** facing the third target **24** are coils for detecting a position of the third target **24** in the circumferential direction Dc. Therefore, the first reception coil **32** and the second reception coil **33** facing the third target **24** output detection signals corresponding to the position of the third target **24**.

[0072] The first reception coil **32** and the second reception coil **33** facing the fourth target **25** are coils for detecting a position of the fourth target **25** in the circumferential direction Dc. Therefore, the first reception coil **32** and the second reception coil **33** facing the fourth target **25** output detection signals corresponding to the position of the fourth target **25**. Therefore, the first reception coil **32** and the second reception coil **33** facing the second target **23**, the third target **24**, and the fourth target **25** respectively function as a signal output unit that outputs a signal corresponding to the rotation position of the rotation member **20**.

[0073] As shown in FIG. **4**, the first positive spiral portions **32**a and the first reverse spiral portions **32**b of the eight first reception coils **32** and the second positive spiral portions **33**a and the second reverse spiral portions **33**b of the eight second reception coils **33** are disposed side by side in the circumferential direction Dc to form an annular shape centered on the rotation shaft center CL. Specifically, the first positive spiral portions **32**a and the first reverse spiral portions **32**b of the eight first reception coils **32** and the second positive spiral portions **33**a and the second reverse spiral portions **33**b of the eight second reception coils **33** are disposed side by side at a pitch of 20 degrees in the circumferential direction Dc about the rotation shaft center CL.

[0074] As described above, the first target **22** reciprocates in the circumferential direction Dc within the first operation range W**1**. The first target **22** is formed not to overlap the first reception coils **32** and the second reception coils **33** facing the second target **23**, the third target **24**, and the fourth target **25** in the axial direction Da.

[0075] The second target **23** reciprocates in the circumferential direction Dc within the second operation range W**2**. The second target **23** is formed not to overlap with the first reception coils **32** and the second reception coils **33** facing the first target **22**, the third target **24**, and the fourth target **25** in the axial direction Da.

[0076] The third target **24** reciprocates in the circumferential direction Dc in the third operation range W**3**. The third target **24** is formed not to overlap the first reception coils **32** and the second reception coils **33** facing the first target **22**, the second target **23**, and the fourth target **25** in the axial direction Da.

[0077] The fourth target **25** reciprocates in the circumferential direction Dc in the fourth operation range W**4**. The fourth target **25** is formed not to overlap the first reception coils **32** and the second reception coils **33** facing the first target **22**, the second target **23**, and the third target **24** in the axial direction Da.

[0078] As shown in FIG. **5**, various electric components are mounted on the substrate **30** in addition to the one transmission coil **31**, the eight first reception coils **32**, the eight second reception coils **33**, and the signal processing circuit **40**. For example, a coupling wiring **35** for coupling the one transmission coil **31**, the eight first reception coils **32**, and the eight second reception coils **33** to the signal processing circuit **40** are provided in the substrate **30**. The signal processing circuit **40** is coupled to the one transmission coil **31**, the eight first reception coils **32**, and the eight second reception coils **33** via the coupling wiring **35**.

[0079] The signal processing circuit **40** includes a microcomputer equipped with a CPU and storage units such as an ROM, an RAM, and a non-volatile RAM, and is coupled to the transmission coil **31**, the first reception coil **32**, and the second reception coil **33**. The signal

processing circuit **40** implements various control operations by the CPU reading and executing programs from the ROM or the non-volatile RAM. The ROM or the non-volatile RAM stores in advance various types of data (for example, initial values, look-up tables, and maps) used when the programs are executed. The storage medium such as the ROM is a non-transitory tangible storage medium. The CPU is an abbreviation for Central Processing Unit, the ROM is an abbreviation for Read Only Memory, and the RAM is an abbreviation for Random Access Memory.

[0080] Specifically, as shown in FIG. **5**, the signal processing circuit **40** includes a signal processing unit **50** that is coupled to the one transmission coil **31**, the eight first reception coils **32**, and the eight second reception coils **33** and performs predetermined processing. The signal processing unit **50** includes an oscillation unit **51**, a demodulation unit **52**, an AD conversion unit **53**, an angle calculation unit **80**, an output unit **57**, and a power supply unit **58**. In the following, a typical example of converting a signal into a digital signal will be described. However, in the case of processing with an analog signal, the signal processing unit **50** may not include the AD conversion unit **53** and the like.

[0081] In the present embodiment, the eight first reception coils **32** and the eight second reception coils **33** output voltage values corresponding to the positions of the four targets **22** to **25**. When the voltage values are output from the eight first reception coils **32** and the eight second reception coils **33** to the signal processing unit **50**, control processing executed by the signal processing unit **50** is the same.

[0082] Therefore, in FIG. **5**, among the eight first reception coils **32** and the eight second reception coils **33**, only the first reception coil **32** and the second reception coil **33** facing the first target **22** are shown. In the following, the first voltage value V**1** and the second voltage value V**2** when the first reception coil **32** and the second reception coil **33** facing the first target **22** output voltage values corresponding to the position of the first target **22** will be described. The first voltage value V**1** is a voltage value output by the first reception coil **32** according to the position of the first target **22**. The second voltage value V**2** is a voltage value output by the second reception coil **33** according to the position of the first target **22**.

[0083] First, an alternating current having a predetermined frequency is applied from the oscillation unit **51** to the transmission coil **31**. Accordingly, electromagnetic induction is generated in the transmission coil **31**. The transmission coil **31** and the first reception coil **32** are inductively coupled to each other by the generated electromagnetic induction. In addition, the transmission coil **31** and the second reception coil **33** are inductively coupled to each other by the generated electromagnetic induction. Magnetic fields passing through the first reception coil **32** and the second reception coil **33** in the axial direction Da are generated around the first positive spiral portion **32***a* and the first reverse spiral portion **32***b* of the first reception coil **32** and around the second positive spiral portion **33***a* and the second reverse spiral portion **33***b* of the second reception coil **33**. A magnetic field generated by the alternating current changes, and thus the first voltage value V**1**, which is an induced electromotive force generated in the first reception coil **32**, and the second voltage value V**2**, which is an induced electromotive force generated in the second reception coil **33**, are changed by the electromagnetic induction.

[0084] When the first target **22** faces the first reception coil **32** and the second reception coil **33**, an eddy current, which is an induced current, is generated in the first target **22** by the electromagnetic induction, and a magnetic field is generated due to the eddy current. Therefore, of the magnetic fields in the axial direction Da passing through the first reception coil **32** and the second reception coil **33**, a magnetic field passing through a portion facing the first target **22** is offset by the magnetic field caused by the eddy current. Accordingly, the first voltage value V**1** generated in the first reception coil **32** and the second voltage value V**2** generated in the second reception coil **33** change.

[0085] As the rotation member **20** rotates, an area of the first reception coil **32** and the second reception coil **33** facing the first target **22** changes. Of the magnetic fields in the axial direction Da

passing through the first reception coil **32** and the second reception coil **33**, a magnitude of the magnetic field passing through the portion facing the first target **22** changes periodically. Thus, the rotation member **20** according to the present embodiment changes the first voltage value V**1** generated in the first reception coil **32** and the second voltage value V**2** generated in the second reception coil **33** according to the rotation position of the rotation member **20**.

[0086] Therefore, as shown in FIG. **6**, as the rotation position of the rotation member **20** is changed, the first voltage value V**1** generated in the first reception coil **32** and the second voltage value V**2** generated in the second reception coil **33** periodically change.

[0087] For example, when the portion of the first target **22** facing the first reverse spiral portion **32***b* is larger than the first positive spiral portion **32***a* in the first reception coil **32**, the first voltage value V**1** is a voltage value on a plus side of a center of an amplitude in the first voltage value V**1** having a sine wave shape. In addition, for example, when a portion of the first target **22** facing the first positive spiral portion **32***a* is larger than the first reverse spiral portion **32***b* in the first reception coil **32**, a voltage value on a minus side of the center of the amplitude in the first voltage value V**1** having the sine wave shape is output.

[0088] For example, when a portion of the first target **22** facing the second reverse spiral portion **33***b* is larger than the second positive spiral portion **33***a* in the second reception coil **33**, the second voltage value V**2** is a voltage value on a plus side of a center of an amplitude in the second voltage value V**2** having a cosine wave shape. In addition, for example, when a portion of the first target **22** facing the second positive spiral portion **33***a* is larger than the second reverse spiral portion **33***b* in the second reception coil **33**, a voltage value on a minus side of the center of the amplitude in the second voltage value V**2** having the cosine wave shape is output.

[0089] The first reception coil **32** and the second reception coil **33** are provided such that a waveform of the first voltage value V**1** and a waveform of the second voltage value V**2** are different by 90° in electric angle. Therefore, in the present embodiment, the first voltage value V**1** generated in the first reception coil **32** has the sine wave shape corresponding to the rotation position of the first target **22**. The second voltage value V**2** generated in the second reception coil **33** has a wave shape whose phase is different from that of the first voltage value V**1**, and has the cosine wave shape corresponding to the rotation position of the first target **22**.

[0090] In the substrate **30** according to the present embodiment, the eight first reception coils **32** and the eight second reception coils **33** are arranged in the circumferential direction Dc to form an annular shape centered on the rotation shaft center CL. When the rotation member **20** is temporarily rotatable by 360°, the four targets **22** to **25** pass in front of the eight first reception coils **32** and the eight second reception coils **33** during one rotation of the rotation member **20**.

[0091] In the position detection device **1** having such a configuration, the first reception coil **32** and the second reception coil **33** of the substrate **30** have a four-pole configuration. In the first reception coil **32** and the second reception coil **33** having the four-pole configuration, the voltage values output by the eight first reception coils **32** and the eight second reception coils **33** change four times in positive and negative during one rotation of the rotation member **20**. That is, during one rotation of the rotation member **20** in a range of 0° to 360° of a mechanical angle, which is a rotation angle of the rotation member **20**, an electric angle of the first reception coil **32** and the second reception coil **33** is four rotations in the range of 0° to 360°. In other words, one rotation of the electric angle, that is, a rotation range from 0° to 360° corresponds to a rotation range of 0° to 90° of the mechanical angle.

[0092] Next, an operation of the signal processing unit **50** will be described. The signal processing unit **50** is a calculation unit that calculates the rotation position of the rotation member **20** based on the first voltage value V**1** output by the first reception coil **32** and the second voltage value V**2** output from the second reception coil **33**. That is, the signal processing unit **50** is a calculation unit that calculates a detection body position as the position of the rotation member **20** which is a detection body.

[0093] As shown in FIG. **5**, the oscillation unit **51** is coupled to both ends of the transmission coil **31**, and applies an alternating current having a predetermined frequency. Two capacitors **36** and **37** are coupled in series between the both ends of the transmission coil **31** and the oscillation unit **51**, and a part coupling the two capacitors **36** and **37** to each other is coupled to ground. The transmission coil **31** generates a magnetic field in the axial direction Da passing through the first reception coil **32** and the second reception coil **33**. However, a method for connecting the transmission coil **31** and the oscillation unit **51** can be appropriately changed. For example, one capacitor may be disposed between the both ends of the transmission coil **31** and the oscillation unit **51**.

[0094] The demodulation unit **52** is coupled to both ends of the first reception coil **32** and both ends of the second reception coil **33**. The demodulation unit **52** generates a first demodulation signal VD**1** in which the first voltage value V**1** of the first reception coil **32** is demodulated, and generates a second demodulation signal VD**2** in which the second voltage value V**2** of the second reception coil **33** is demodulated.

[0095] The AD conversion unit **53** is coupled to the demodulation unit **52** and the angle calculation unit **80**. The AD conversion unit **53** outputs, to the angle calculation unit **80**, a first conversion signal Si obtained by performing AD conversion on the first demodulation signal VD**1** and a second conversion signal Co obtained by performing AD conversion on the second demodulation signal VD**2**.

[0096] In the magnetic fields in the axial direction Da passing through the first reception coil **32** and the second reception coil **33**, magnetic fluxes change based on a size of the gap G between the rotation member **20** and the substrate **30**. Therefore, the first voltage value V**1** generated in the first reception coil **32** due to the magnetic field passing through the first reception coil **32** in the axial direction Da changes based on the gap G between the rotation member **20** and the substrate **30**. The second voltage value V**2** generated in the second reception coil **33** due to the magnetic field passing through the second reception coil **33** in the axial direction Da changes based on the gap G between the rotation member **20** and the substrate **30**.

[0097] Accordingly, in the first conversion signal Si based on the first voltage value V**1** of the first reception coil **32** and the second conversion signal Co based on the second voltage value V**2** of the second reception coil **33**, amplitudes change according to the gap G, as shown in FIG. **6**. Specifically, in the first conversion signal Si based on the first voltage value V**1** and the second conversion signal Co based on the second voltage value V**2**, the amplitudes decrease as the gap G increases, and the amplitudes increase as the gap G decreases.

[0098] FIG. **6** shows an example in which the amplitudes of the first conversion signal S**1** and the second conversion signal Co change according to the gap G when the rotation range of the rotation member **20** is a mechanical angle of 0° to 90° and a range of the electric angle of the first reception coil **32** and the second reception coil **33** is 0° to 360°. Specifically, a solid line a indicates the first conversion signal Si when the gap G is set to 2 mm. A solid line b indicates the first conversion signal Si when the gap G is set to 2.5 mm. A solid line c indicates the first conversion signal Si when the gap G is set to 3 mm. A solid line d indicates the first conversion signal Si when the gap G is set to 3.5 mm. A solid line e indicates the first conversion signal Si when the gap G is set to 4 mm.

[0099] A solid line f in FIG. **6** indicates the second conversion signal Co when the gap G is set to 2 mm. A solid line g indicates the second conversion signal Co when the gap G is set to 2.5 mm. A solid line h indicates the second conversion signal Co when the gap G is set to 3 mm. A solid line i indicates the second conversion signal Co when the gap G is set to 3.5 mm. A solid line j indicates the second conversion signal Co when the gap G is set to 4 mm.

[0100] The solid line a, the solid line b, the solid line c, the solid line d, the solid line e, the solid line f, the solid line g, the solid line h, the solid line i, and the solid line j are the same in FIG. **8** described later.

[0101] Thus, in the first conversion signal Si based on the first voltage value V**1** and the second conversion signal Co based on the second voltage value V**2**, the amplitudes change according to the gap G. As will be specifically described later, when a position calculation unit **55** calculates a rotation angle θ, the position calculation unit **55** calculates the rotation angle θ based on the first conversion signal Si based on the first voltage value V**1** and the second conversion signal Co based on the second voltage value V**2**. Therefore, when the rotation member **20** and the substrate **30** are assembled to the rotation shaft **70**, the gap G is preferably set to a preset design value. Accordingly, when an angle is calculated by the position calculation unit **55**, the rotation angle θ can be calculated in consideration of a magnitude of the amplitude corresponding to the gap G.

[0102] However, the gap G between the rotation member **20** and the substrate **30** may deviate from the design value due to assembly errors and manufacturing errors when the rotation member **20** and the substrate **30** are assembled to the rotation shaft **70**. For example, even when the design value of the gap G is 3 mm, an actual gap G may deviate from 3 mm to 2 mm or 4 mm due to the assembly errors and the manufacturing errors when the rotation member **20** and the substrate **30** are assembled to the rotation shaft **70**. When the amplitudes of the first conversion signal Si and the second conversion signal Co are changed due to the deviation of the gap G from the design value, an error is generated in a calculation result when the position calculation unit **55** calculates the rotation angle θ based on the first conversion signal Si and the second conversion signal Co.

[0103] When the first conversion signal Si based on the first voltage value V**1** has a sine wave shape, a gain, an offset, and a phase of the first conversion signal Si having the sine wave shape change according to the gap G. Accordingly, the first conversion signal Si based on the first voltage value V**1** may be distorted from an ideal sine wave shape according to the gap G. In this case, a shape indicated by the first conversion signal Si based on the first voltage value V**1** is a sine wave shape distorted with respect to the ideal sine wave shape. In other words, the first voltage value V**1** has a sine wave shape including distortion.

[0104] When the second conversion signal Co based on the second voltage value V**2** has a cosine wave shape, a gain, an offset, and a phase of the second conversion signal Co having the cosine wave shape change according to the gap G. Accordingly, the second conversion signal Co based on the second voltage value V**2** may be distorted from an ideal sine wave shape according to the gap G. In this case, a shape indicated by the second conversion signal Co based on the second voltage value V**2** is a cosine wave shape distorted with respect to the ideal cosine wave shape. In other words, the second voltage value V**2** has a cosine wave shape including distortion.

[0105] The distortion of the first conversion signal Si from the ideal sine wave shape and the distortion of the second conversion signal Co from the ideal cosine wave shape also cause an error in the calculation result when the position calculation unit **55** calculates the rotation angle θ.

[0106] Therefore, the angle calculation unit **80** corrects the first conversion signal Si and the second conversion signal Co by correcting a gain (G), an offset (O), and a phase (P) used for calculating the rotation angle θ using the first conversion signal Si and the second conversion signal Co. The angle calculation unit **80** derives tan θ, which will be described later, for calculating an angle by calculating an arc tangent function using the corrected first conversion signal S**1** and the corrected second conversion signal Co, and calculates the position of the rotation member **20** based on the derived tan θ. For example, as shown in FIG. **7**, the angle calculation unit **80** according to the present embodiment includes a GOP correction unit **54** that corrects the first conversion signal S**1** and the second conversion signal Co, the position calculation unit **55** that calculates the rotation angle θ, and a section correction unit **56** that corrects the rotation angle θ calculated by the position calculation unit **55**.

[0107] The signal processing unit **50** according to the present embodiment may function as the GOP correction unit **54**, the position calculation unit **55**, and the section correction unit **56**. The signal processing unit **50** may include one circuit module capable of performing the functions of the GOP correction unit **54**, the position calculation unit **55**, and the section correction unit **56**. The

signal processing unit **50** may include multiple circuit modules corresponding one-to-one to the GOP correction unit **54**, the position calculation unit **55**, and the section correction unit **56**.

[0108] The GOP correction unit **54** corrects the first conversion signal S**1** and the second conversion signal Co by using one correction term among a gain correction term, an offset correction term, and a phase correction term for each of the first conversion signal S**1** and the second conversion signal Co. The tan θ is derived using the corrected first conversion signal S**1** and second conversion signal Co and the following Mathematical Formula 1. Thus, the GOP correction unit **54**, which corrects the first voltage value V**1** converted into the first conversion signal S**1** and the second voltage value V**2** converted into the second conversion signal Co using a first correction term and a second correction term described later, functions as a signal correction unit. In other words, the GOP correction unit **54** corrects the first conversion signal Si based on the first voltage value V**1** and the second conversion signal Co based on the second voltage value V**2**.

[00001] $\tan\theta = \dfrac{C\{(A1\sin\theta + B1) - (A2\cos\theta + B2)\}}{(A1\sin\theta + B1) + (A2\cos\theta + B2)}$ (MathematicalFormula1)

[0109] In Mathematical Formula 1, A**1** is a gain correction term for correcting the gain of the first conversion signal Si, and A**2** is a gain correction term for correcting the gain of the second conversion signal Co. In Mathematical Formula 1, B**1** is an offset correction term for correcting the offset of the first conversion signal Si, and B**2** is an offset correction term for correcting the offset of the second conversion signal Co. In Mathematical Formula 1, C is a phase correction term for correcting the phases of the first conversion signal S**1** and the second conversion signal Co. As shown in Mathematical Formula 1, Mathematical Formula 1 is based on the first conversion signal Si based on the first voltage value V**1** having the sine wave shape and the second conversion signal Co based on the second voltage value V**2** having the cosine wave shape.

[0110] Hereinafter, the gain correction term for correcting the gain of the first conversion signal Si is also referred to as a first gain correction term, and the offset correction term for correcting the offset of the first conversion signal Si is also referred to as a first offset correction term. The gain correction term for correcting the gain of the second conversion signal Co is also referred to as a second gain correction term, and the offset correction term for correcting the offset of the second conversion signal Co is also called a second offset correction term. The phase correction term for correcting the phase of each of the first conversion signal S**1** and the second conversion signal Co is also simply referred to as a phase correction term.

[0111] In the present embodiment, the first gain correction term and the first offset correction term correspond to the first correction term, and the second gain correction term and the second offset correction term correspond to the second correction term. Hereinafter, the first gain correction term and the first offset correction term may be simply referred to as the first correction term, and the second gain correction term and the second offset correction term may be simply referred to as the second correction term.

[0112] The first correction term, the second correction term, and the phase correction term can be obtained by, for example, taking the first conversion signal Si and the second conversion signal Co obtained in a state where the rotation member **20** and the substrate **30** are assembled to the rotation shaft **70** in advance, into an external device different from the position detection device **1**. The external device may be implemented by a CPU, a storage unit such as a ROM, a RAM, or a non-volatile RAM, or a microcomputer including an input and output interface. In this case, the external device is capable of deriving the first correction term, the second correction term, and the phase correction term based on a control program stored in the ROM and the like and the input first conversion signal S**1** and second conversion signal Co.

[0113] The external device transmits information of the derived first correction term, second correction term, and phase correction term to the GOP correction unit **54** and stores the information in the GOP correction unit **54**. Accordingly, when the first conversion signal S**1** and the second conversion signal Co output from the AD conversion unit **53** are received, the GOP correction unit

54 corrects the first conversion signal S**1** and the second conversion signal Co using the stored first correction term, second correction term, and phase correction term. Based on Mathematical Formula 1, the GOP correction unit **54** derives the tan θ for the position calculation unit **55** calculating the angle.

[0114] The GOP correction unit **54** according to the present embodiment corrects the first conversion signal S**1** and the second conversion signal Co using the first gain correction term, the first offset correction term, the second gain correction term, and the second offset correction term among the first gain correction term, the first offset correction term, the second gain correction term, the second offset correction term, and the phase correction term. Therefore, the GOP correction unit **54** according to the present embodiment does not correct the phases of the first conversion signal Si and the second conversion signal Co. Accordingly, the GOP correction unit **54** according to the present embodiment derives the tan θ using Mathematical Formula 1 in which 1 is substituted into C as the phase correction term.

[0115] A method for deriving the first gain correction term, the first offset correction term, the second gain correction term, and the second offset correction term will be described. The first gain correction term and the first offset correction term are derived such that the first conversion signal Si approaches the ideal sine wave shape as shown in FIG. **8**. The second gain correction term and the second offset correction term are derived such that the second conversion signal Co approaches the ideal cosine wave shape as shown in FIG. **8**. Further, the first gain correction term, the first offset correction term, the second gain correction term, and the second offset correction term are derived such that a difference, between an error when the gap G is the design value and an error when the gap G deviates from the design value, becomes smaller.

[0116] The first conversion signal Si has the sine wave shape as shown in FIG. **6**, and the second conversion signal Co has the cosine wave shape as shown in FIG. **6**. The first conversion signal Si shown in FIG. **6** has the sine wave shape that includes distortion with respect to the ideal sine wave shape and has frequency components (not shown) superimposed thereon. The second conversion signal Co shown in FIG. **6** has the cosine wave shape that includes distortion with respect to the ideal sine wave shape and has frequency components (not shown) superimposed thereon.

[0117] In such a case, the first gain correction term and the first offset correction term are derived such that the first conversion signal Si approaches the ideal sine wave shape. The second gain correction term and the second offset correction term are derived such that the second conversion signal Co approaches the ideal cosine wave shape.

[0118] The position detection device **1** according to the present embodiment is used to detect the rotation position of the pedal that reciprocates within the predetermined angle range about the rotation shaft center CL. Specifically, the position detection device **1** according to the present embodiment detects the rotation position of the rotation member **20** that reciprocates within the angle range of 0° to 24° about the rotation shaft center CL when the stepping-on operation of the pedal is performed. In this case, a detection range of the rotation member **20** detected by the position detection device **1** is 0° to 24°.

[0119] Therefore, in the position detection device **1** that detects the detection range of 0° to 24°, it is not necessary to derive the first gain correction term, the first offset correction term, the second gain correction term, and the second offset correction term to reduce an error of the rotation position outside the detection range. In other words, the position detection device **1** that detects the detection range of 0° to 24° may derive the first gain correction term, the first offset correction term, the second gain correction term, and the second offset correction term such that an error of the rotation position within the detection range becomes small.

[0120] Therefore, in the present embodiment, the first gain correction term and the first offset correction term are derived such that the first conversion signal Si approaches the ideal sine wave shape within the angle range of 0° to 24° as the detection range. The second gain correction term and the second offset correction term are derived such that the second conversion signal Co

approaches the ideal cosine wave shape within the angle range of 0° to 24° as the detection range.

[0121] Thus, the first correction term and the second correction term are derived only in the angle range detected by the position detection device **1**. The mechanical angle, which is the rotation angle of the rotation member **20**, is obtained using the derived first correction term and second correction term. A relationship between the rotation angle of the rotation member **20** and the electric angle of the first reception coil **32** is shown in FIG. **9**. Specifically, the rotation angle (that is, the mechanical angle) of the rotation member **20** is proportional to the electric angle of the first reception coil **32**. Regardless of the gap G, a relative relationship between the mechanical angle of the rotation member **20** and the electric angle of the first reception coil **32** is substantially the same.

[0122] According to this, regardless of the size of the gap G, the error of the rotation angle can be made relatively smaller within the angle range of 0° to 24° than the error within the angle range larger than 24°, as shown in FIG. **10**.

[0123] A solid line A shown in FIG. **10** indicates an error of the rotation angle when the design value of the actual gap G is set to 2 mm in a case where the design value of the gap G is set to 3 mm when the rotation member **20** and the substrate **30** are assembled to the rotation shaft **70**. A solid line B indicates an error of the rotation angle when the actual gap G is set to 2.5 mm in a case where the design value of the gap G is set to 3 mm. A solid line C indicates an error of the rotation angle when the design value of the actual gap G is set to 3 mm in a case where the design value of the gap G is set to 3 mm. A solid line D indicates an error of the rotation angle when the actual gap G is set to 3.5 mm in a case where the design value of the gap G is set to 3 mm. A solid line E indicates an error of the rotation angle when the actual gap G is set to 4 mm in a case where the design value of the gap G is set to 3 mm. For the error of the rotation angle, the amplitude decreases as the gap G increases, and the amplitude increases as the gap G decreases.

[0124] However, as shown in FIG. **10**, the error when the gap G is deviated from the design value is larger than the error when the gap G is the design value. The design value is the size of the gap G serving as a reference when the rotation member **20** and the substrate **30** are assembled to the rotation shaft **70**. Therefore, the error, in a case where the size of the gap G is 2 mm, 2.5 mm, 3.5 mm, and 4 mm which are sizes deviated from the reference gap, is larger than the error in a case where the gap G is 3 mm which is the reference gap. Accordingly, the first correction term and the second correction term are derived such that the difference, between the error when the gap G is the design value and the error when the gap G deviates from the design value, becomes smaller.

[0125] In the following, among these gaps G that deviate from the design value, the gaps G of 2 mm and 2.5 mm, which are intervals between the rotation member **20** and the substrate **30** smaller than the reference gap, are defined as near gaps. Among these gaps G that deviate from the design value, the gaps G of 3.5 mm and 4 mm, which are intervals between the rotation member **20** and the substrate **30** larger than the reference gap, are defined as far gaps.

[0126] The reference gap is set to 3 mm which is a center between the size of the gap G farthest from the reference gap among 2 mm and 2.5 mm as the near gaps and the gap G farthest from the reference gap among 3.5 mm and 4 mm as the far gaps.

[0127] The error when the gap G shown in FIG. **10** is 3 mm is defined as a reference error, and the error when the gap G is 2 mm, 2.5 mm, 3.5 mm, and 4 mm is defined as an out-of-reference error.

[0128] The first correction term and the second correction term are derived such that the reference error and the out-of-reference error for each mechanical angle within the angle range of 0° to 24° approach 0. The first correction term and the second correction term according to the present embodiment are derived such that the difference between the reference error and each of the four out-of-reference errors becomes smaller with the reference error as a reference. Specifically, the first gain correction term and the first offset correction term are derived such that an absolute value of a value, which is obtained by subtracting each of the four out-of-reference errors from the reference error for each mechanical angle within the angle range of 0° to 24°, becomes smaller. The second gain correction term and the second offset correction term are derived such that an absolute

value of a value, which is obtained by subtracting each of the four out-of-reference errors from the reference error for each mechanical angle within the angle range of 0° to 24°, becomes smaller.

[0129] Thus, the first correction term and the second correction term are derived such that the difference between the error when the gap G is the design value and the error when the gap G is deviated from the design value becomes smaller, and the mechanical angle which is the rotation angle of the rotation member 20 is obtained. As shown in FIG. 11, even when the gap G is the design value and even when the gap G is deviated from the design value, the error for each mechanical angle of the rotation angle θ calculated by the position calculation unit 55 can be reduced.

[0130] Thus, the reason why the first correction term and the second correction term are derived such that the difference between the error when the gap G is the design value and the error when the gap G is deviated from the design value becomes smaller will be described.

[0131] As described above, in the magnetic fields in the axial direction Da passing through the first reception coil 32 and the second reception coil 33, the magnetic fluxes change based on the size of the gap G between the rotation member 20 and the substrate 30. Therefore, the first voltage value V1 generated in the first reception coil 32 and the second voltage value V2 generated in the second reception coil 33 change based on the gap G between the rotation member 20 and the substrate 30. Accordingly, the amplitudes and the offsets of the first conversion signal Si based on the first voltage value V1 and the second conversion signal Co based on the second voltage value V2 change according to the gap G. The change in the amplitude and the change in the offset for the first conversion signal S1 and the second conversion signal Co are factors that cause an error in the rotation angle θ calculated by the position calculation unit 55.

[0132] According to intensive studies by inventors, as shown in FIG. 12, it has been found that the offset of each of the first conversion signal S1 and the second conversion signal Co changing according to the gap G includes an offset component independent of the change in the amplitude and an offset component that changes according to the change in the amplitude. Specifically, it is found that an amount of change according to the change in the gap G is smaller in the offset component independent of the change in the amplitude than in the offset component that changes according to the change in the amplitude. For example, in an example shown in FIG. 12, the offset component independent of the change in the amplitude hardly changes in magnitude regardless of the size of the gap G, and is substantially constant. The offset component independent of the change in the amplitude is caused by, for example, a fact that a wiring pattern and the like different from the transmission coil 31, the first reception coil 32, and the second reception coil 33 in the substrate 30 has a coil component.

[0133] On the other hand, the offset component that changes according to the change in the amplitude increases as the gap G decreases, and decreases as the gap G increases. In other words, the offset component that changes according to the change in the amplitude when the gap G is a near gap is larger than that when the gap G is a far gap. In the present embodiment, the magnitude of the offset component that changes according to the change in the amplitude decreases proportionally as the gap G decreases.

[0134] In FIG. 12, the offset component independent of the change in the amplitude is indicated by white, and the offset component that changes according to the change in the amplitude is indicated by hatching. In the following, in the offset of the first conversion signal Si, the offset component independent of the change in the amplitude of the first conversion signal Si is also referred to as a first static offset, and the offset component in which the magnitude of the signal changes according to the change in the amplitude of the first conversion signal Si is also referred to as a first variable offset. In the offset of the second conversion signal Co, the offset component independent of the change in the amplitude of the second conversion signal Co is also referred to as a second static offset, and the offset component in which the magnitude of the signal changes according to the change in the amplitude of the second conversion signal Co is also referred to as a second variable

offset.

[0135] A magnitude of the first static offset is hardly changed according to the change in the amplitude of the first conversion signal Si, but the first static offset does not necessarily mean that the magnitude is constant. A magnitude of the second static offset is hardly changed according to the change in the amplitude of the second conversion signal Co, but the second static offset does not necessarily mean that the magnitude is constant.

[0136] The amplitude of each of the first conversion signal S1 and the second conversion signal Co increases as the gap G decreases, and decreases as the gap G increases. Therefore, as the gap G increases, the influence of the change in the offset of each of the first conversion signal S1 and the second conversion signal Co increases.

[0137] As described above, the first conversion signal Si has the sine wave shape in which the frequency components are superimposed. The second conversion signal Co has the cosine wave shape in which the frequency components are superimposed. According to further intensive studies by the inventors, it is found that the frequency components superimposed on the first conversion signal S1 and the second conversion signal Co each include a high-order component in addition to a zeroth-order component and a primary component, and the components included in the frequency component are different according to the gap G. Specifically, it is found that the high-order component superimposed on the first conversion signal S1 and the second conversion signal Co has a tendency that the high-order component of the frequency component increases as the gap G decreases and the high-order component of the frequency component decreases as the gap G increases.

[0138] For example, in the high-order component superimposed on the first conversion signal S1 and the second conversion signal Co, when the gap G is a near gap, the secondary or higher order of the high-order component increases as compared with the case where the gap G is a far gap. In the high-order component superimposed on the first conversion signal S1 and the second conversion signal Co, when the gap G is a near gap, the primary or lower order component decreases as compared with the case where the gap G is a far gap, and the component of the zeroth-order component decreases as the size of the gap G decreases.

[0139] On the other hand, when the gap G is a far gap, the high-order component superimposed on the first conversion signal S1 and the second conversion signal Co includes a large amount of the zeroth-order component as compared with the case where the gap G is a near gap. When the gap G is a far gap, the high-order component superimposed on the first conversion signal S1 and the second conversion signal Co includes a large amount of the zeroth-order component compared to another components. The zeroth-order component superimposed on the first conversion signal Si is caused by the first static offset and the first variable offset. The zeroth-order component superimposed on the second conversion signal Co is caused by the second static offset and the second variable offset.

[0140] The above is found by the inventors variously changing a setting value of the gap G between the rotation member 20 and the substrate 30, and performing FFT analysis on the first conversion signal S1 and the second conversion signal Co in the setting values of the gaps G.

[0141] The position calculation unit 55 calculates the rotation angle θ by calculating an arc tangent function using the first conversion signal S1 and the second conversion signal Co and performing arc tangent conversion on the first conversion signal Si and the second conversion signal Co. Therefore, the frequency component superimposed on the first conversion signal S1 and the second conversion signal Co is a factor causing the error in the calculation result of the rotation angle θ calculated by the position calculation unit 55. The frequency components superimposed on the first conversion signal S1 and the second conversion signal Co is subjected to the arc tangent conversion. An order number of each component becomes one larger than that before the arc tangent conversion.

[0142] For example, the secondary component superimposed on the first conversion signal S1 and

the second conversion signal Co becomes a tertiary component by performing the arc tangent conversion. The zeroth-order component superimposed on the first conversion signal S1 and the second conversion signal Co becomes a primary component by performing the arc tangent conversion.

[0143] Therefore, when the gap G is a near gap, a large amount of the secondary or higher order of the high-order component is included compared to the primary or lower order component, and the rotation angle θ calculated by performing the arc tangent conversion on the first conversion signal S1 and the second conversion signal Co includes an error of the tertiary or higher order of the high-order component. However, the first conversion signal S1 and the second conversion signal Co when the gap G is a near gap have fewer primary or lower order component as compared with the case where the gap G is a far gap. Therefore, the error of the rotation angle θ when the gap G is a near gap almost does not include the secondary or lower order component as compared with the case where the gap G is a far gap. In this case, in the rotation angle θ calculated by the position calculation unit 55 within the angle range of 0° to 24°, errors of the tertiary or higher order of the high-order component are superimposed within the entire angle range.

[0144] On the other hand, when the gap G is a far gap, a large amount of the zeroth-order component is included compared to the other components, and the rotation angle θ calculated by performing the arc tangent conversion on the first conversion signal S1 and the second conversion signal Co includes many errors of the primary component. In this case, in the rotation angle θ calculated by the position calculation unit 55 within the angle range of 0° to 24°, errors that increase proportionally as the calculated rotation angle θ increases are superimposed.

[0145] Thus, when the frequency component is superimposed on the first conversion signal S1 and the second conversion signal Co, the influence of the zeroth-order component on the calculation result of the rotation angle θ becomes larger than that of the high-order component of the frequency component. The zeroth-order component superimposed on the first conversion signal Si is caused by the first static offset and the first variable offset. The zeroth-order component superimposed on the second conversion signal Co is caused by the second static offset and the second variable offset. Therefore, as the gap G increases, the influence of the offset components of the first conversion signal S1 and the second conversion signal Co increases.

[0146] In the present embodiment, the GOP correction unit 54 derives the first correction term and the second correction term such that a difference, between an error when the gap G is a design value and an error when the gap G is a far gap, is reduced. Specifically, the GOP correction unit 54 derives the first offset correction term and the second offset correction term, such that the primary component obtained by the position calculation unit 55 performing the arc tangent conversion on the first conversion signal S1 and the second conversion signal Co, when the gap G is the far gap, approaches the primary component obtained by the position calculation unit 55 performing the arc tangent conversion on the first conversion signal S1 and the second conversion signal Co when the gap G is the near gap.

[0147] By adjusting the first static offset, the GOP correction unit 54 derives the first offset correction term such that a relationship, between an amount of change in the amplitude of the first conversion signal S1 and an amount of change in the offset of the first conversion signal Si based on the amount of change in the amplitude of the first conversion signal Si, becomes a proportional relationship. In other words, the first offset correction term is derived such that the offset of the first conversion signal Si after adjusting the first static offset linearly decreases in proportion to the decrease in the amplitude of the first conversion signal Si.

[0148] For example, as in the present embodiment, when the first variable offset linearly decreases in proportion to the decrease in the amplitude of the first conversion signal Si, the GOP correction unit 54 may derive the first offset correction term that can remove the first static offset in the offset. Accordingly, the relationship, between the amount of change in the amplitude of the first conversion signal S1 and the amount of change in the offset of the first conversion signal Si based

on the amount of change in the amplitude of the first conversion signal Si, can be a proportional relationship in which a proportionality constant is a negative value. Accordingly, an offset that changes in proportion to the amount of change in the amplitude of the first conversion signal Si remains in the first conversion signal Si whose offset is adjusted by the GOP correction unit **54**.

[0149] By adjusting the second static offset, the GOP correction unit **54** derives the second offset correction term such that a relationship, between an amount of change in the amplitude of the second conversion signal Co and an amount of change in the offset of the second conversion signal Co based on the amount of change in the amplitude of the second conversion signal Co, becomes a proportional relationship. In other words, the second offset correction term is derived such that the offset of the second conversion signal Co after adjusting the second static offset linearly decreases in proportion to the decrease in the amplitude of the second conversion signal Co.

[0150] For example, as in the present embodiment, when the second variable offset linearly decreases in proportion to the decrease in the amplitude of the second conversion signal Co, the GOP correction unit **54** may derive the second offset correction term that can remove the second static offset in the offset. Accordingly, the relationship, between the amount of change in the amplitude of the second conversion signal Co and the amount of change in the offset of the second conversion signal Co based on the amount of change in the amplitude of the second conversion signal Co, can be a proportional relationship in which a proportionality constant is a negative value. Accordingly, an offset that changes in proportion to the amount of change in the amplitude of the second conversion signal Co remains in the second conversion signal Co whose offset is adjusted by the GOP correction unit **54**.

[0151] Thus, the offset remaining in the first conversion signal Si that changes in proportion to the amount of change in the amplitude of the first conversion signal Si is a factor causing generation of the zeroth-order component in the frequency component superimposed on the first conversion signal Si. The offset remaining in the second conversion signal Co that changes in proportion to the amount of change in the amplitude of the second conversion signal Co is a factor causing generation of the zeroth-order component in the frequency component superimposed on the second conversion signal Co. The offset remaining in each of the first conversion signal Si and the second conversion signal Co after the offset is adjusted is a primary component obtained by performing the arc tangent conversion using the first conversion signal Si and the second conversion signal Co.

[0152] The primary component, which remains in the rotation angle θ obtained by performing the arc tangent conversion using the first conversion signal S**1** and the second conversion signal Co after the offset is adjusted, can be removed by processing executed by the section correction unit **56** described later.

[0153] By deriving the first correction term and the second correction term as described above, a difference between an error when the gap G is a design value and an error when the gap G is a near gap can be reduced. The influence of the offset component independent of the change in the amplitude can be reduced.

[0154] A method for deriving the first correction term and the second correction term, such that the reference error and the out-of-reference error approach 0, is not limited to the above.

[0155] For example, the method for deriving the first correction term and the second correction term may be derived such that a sum of an absolute value of the reference error and an absolute value of the out-of-reference error for each mechanical angle is a minimum value. The method for deriving the first correction term and the second correction term may be derived using a least squares method. According to the derivation method according to the least squares method, even when noise is superimposed on the first voltage value V**1** and the second voltage value V**2**, the first correction term and the second correction term that can reduce the influence of the noise can be derived.

[0156] Thus, by using the first correction term and the second correction term derived as described above, the GOP correction unit **54** corrects the first conversion signal S**1** and the second conversion

signal Co such that the error when the gap G is the design value and the error when the gap G is deviated from the design value approach 0. The GOP correction unit **54** derives the tan θ using Mathematical Formula 1. The GOP correction unit **54** transmits information of the derived tan θ to the position calculation unit **55**.

[0157] In the example shown in the present embodiment, as shown in FIG. **11**, when the mechanical angle is in an angle range of 0° to 24° and is 0°, 12°, and 21°, the reference error is 0. The reference error is on the plus side which is larger than 0 when the mechanical angle is in a range of 0° to 12° and in a range of 21° to 24°, and is on the minus side which is less than 0 when the mechanical angle is in a range of 12° to 21°. That is, the reference error has a wave shape that changes alternately between the plus side and the minus side in the angle range of the mechanical angle of 0° to 24°.

[0158] The out-of-reference error, when the gap G is the near gap of 2 mm and 2.5 mm, is larger than the reference error in a case where the mechanical angle is in the range of about 2° to about 10° and the values of the errors are compared to each other at the same mechanical angle. The out-of-reference error, when the gap G is the near gap of 2 mm and 2.5 mm, is smaller than the reference error in a case where the mechanical angle is in the range of 0° to about 2° and in the range of 10° to about 24° and the values of the errors are compared to each other at the same mechanical angle.

[0159] Thus, the out-of-reference error, when the gap G is the near gap, changes in a wave shape in the angle range of the mechanical angle of 0° to 24° like the reference error, intersects the reference error, and changes in the value. The value of the out-of-reference error, when the gap G changing in a wave shape is the near gap, changes according to the change in the value of the reference error. That is, the value of the out-of-reference error, when the gap G is the near gap, is on the plus side within a range substantially the same as the range of the mechanical angle in which the reference error is on the plus side. The value of the out-of-reference error, when the gap G is the near gap, is on the minus side in the substantially same range as the range of the mechanical angle in which the reference error is on the minus side.

[0160] The out-of-reference error, when the gap G is the far gap of 3.5 mm and 4 mm, is smaller than the reference error in a case where the mechanical angle is in the range of about 0° to about 13° and in the range of 22° to about 24° and the values of the errors are compared to each other at the same mechanical angle. The out-of-reference error, when the gap G is the far gap of 3.5 mm and 4 mm, is larger than the reference error in a case where the mechanical angle is in the range of 13° to about 22° and the values of the errors are compared to each other at the same mechanical angle.

[0161] Thus, the out-of-reference error, when the gap G is the far gap, changes in a wave shape in the angle range of the mechanical angle of 0° to 24° like the reference error, intersects the reference error, and changes in the value. The value of the out-of-reference error, when the gap G changing in a wave shape is the far gap, changes according to the change in the value of the reference error. That is, the value of the out-of-reference error, when the gap G is the far gap, is on the plus side within a range substantially the same as the range of the mechanical angle in which the reference error is on the plus side. The value of the out-of-reference error, when the gap G is the far gap, is on the minus side in the substantially same range as the range of the mechanical angle in which the reference error is on the minus side.

[0162] The position calculation unit **55** calculates the rotation angle θ which is a detection body position before correction (that is, a pre-correction detection body position) of the rotation member **20** by using the information of the tan θ derived by the GOP correction unit **54**. In the present embodiment, the position calculation unit **55** calculates the rotation angle θ of the rotation member **20** by using the tan θ derived by Mathematical Formula 1.

[0163] The section correction unit **56** is coupled to the position calculation unit **55** and the output unit **57**, and outputs, to the output unit **57**, a correction rotation angle θa obtained by correcting the

rotation angle θ which is the pre-correction detection body position calculated by the position calculation unit **55**. In the present embodiment, the section correction unit **56** calculates the correction rotation angle θa by performing section correction by using an error of the calculated rotation angle θ and a correction function shown in the following Mathematical Formula 2.

[00002] $y = ax +$ (MathematicalFormula2)

[0164] In Mathematical Formula 2, y indicates the correction rotation angle θa which is an output value, and x indicates the rotation angle θ calculated by the position calculation unit **55**. In Mathematical Formula 2, a indicates an inclination correction value, and β indicates an offset correction value.

[0165] The section correction unit **56** derives the inclination correction value α and the offset correction value β for each of multiple sections (that is, a rotation angle range) such that the reference error approaches 0 for each section set in advance. In the example of the present embodiment, as shown in FIG. **13**, the angle range of 0° to 24°, which is the detection range, is divided into seven sections.

[0166] The correction function shown in Mathematical Formula 2 indicates a relationship between a mechanical angle and an error of the rotation angle θ in each of the seven sections, and is based on the rotation angle θ calculated by the position calculation unit **55**. The section correction unit **56** derives the inclination correction value α and the offset correction value β for each of the seven sections. The section correction unit **56** calculates the correction rotation angle θa by correcting the rotation angle θ for each of the seven sections by using the rotation angle θ calculated by the position calculation unit **55**, the derived inclination correction value α, and the offset correction value β.

[0167] Accordingly, as shown in FIG. **13**, a reference error of the correction rotation angle θa can be made closer to 0 in comparison with a reference error of the rotation angle θ shown in FIG. **13**, with the gap G being 3 mm which is a design value.

[0168] In the section correction unit **56**, the position calculation unit **55** calculates the correction rotation angle θa based on the rotation angle θ obtained by performing the arc tangent conversion using the first conversion signal S**1** and the second conversion signal Co. As described above, the zeroth-order component of the frequency component is superimposed on the first conversion signal S**1** and the second conversion signal Co, which are used for obtaining the rotation angle θ. The zeroth-order component superimposed on the first conversion signal S**1** and the second conversion signal Co is a factor that causes the error included in the rotation angle θ to be larger than the high-order component of the frequency component. This is because when the rotation angle θ is obtained by performing the arc tangent conversion on the first conversion signal S**1** and the second conversion signal Co, the zeroth-order component superimposed on the first conversion signal S**1** and the second conversion signal Co becomes a primary component.

[0169] The first conversion signal Si corrected by the GOP correction unit **54** includes an offset, which changes according to the amount of change in the amplitude of the first conversion signal Si, as a factor causing generation of the zeroth-order component. The second conversion signal Co corrected by the GOP correction unit **54** includes an offset, which changes according to the amount of change in the amplitude of the second conversion signal Co, as a factor causing generation of the zeroth-order component.

[0170] The section correction unit **56** according to the present embodiment performs the section correction using the correction function shown in Mathematical Formula 2 to remove the primary component included in the rotation angle θ which is obtained by performing the arc tangent conversion using the first conversion signal Si and the second conversion signal Co. In other words, the section correction unit **56** performs the section correction in order to remove the primary component remaining in the rotation angle θ which is obtained by performing the arc tangent conversion using the first conversion signal S**1** and the second conversion signal Co after the offset

is adjusted by the GOP correction unit **54**.

[0171] The section correction unit **56** may derive the inclination correction value α and the offset correction value β for each of seven or less sections or for each of seven or more sections.

[0172] It is possible to reduce a difference between the largest error and the smallest error in all the out-of-reference errors. In the example shown in the present embodiment, the out-of-reference error is the largest error among all the out-of-reference errors when the gap G is the near gap of 2 mm and the mechanical angle is 8°. The out-of-reference error is the smallest error among all the out-of-reference errors when the gap G is the near gap of 2 mm and the mechanical angle is 16°. The difference between the largest error and the smallest error is 0.18 deg.

[0173] As described above, the value of the out-of-reference error for each of the gaps G of 2 mm, 2.5 mm, 3.5 mm, and 4 mm changes in a wave shape in the angle range of the mechanical angle of 0° to 24°, like the reference error. The value of the out-of-reference error is on the plus side within a range substantially the same as the range of the mechanical angle in which the reference error is on the plus side. The value of the out-of-reference error is on the minus side within a range substantially the same as the range of the mechanical angle in which the reference error is on the minus side.

[0174] Therefore, even when the gap G is out of the design value due to an assembly error and the like of the rotation member **20** and the substrate **30**, the out-of-reference error can be brought close to 0 by using the inclination correction value α and the offset correction value β derived such that the reference error approaches 0.

[0175] For example, the reference error is on the plus side which is larger than 0 when the mechanical angle is in the range of 0° to 12° and in the range of 21° to 24°. Therefore, by using the inclination correction value α and the offset correction value β derived such that the reference error approaches 0, the reference error is decreased and brought close to 0 when the mechanical angle is in the range of 0° to 12° and in the range of 21° to 24°. That is, the reference error is corrected to the minus side when the mechanical angle is in the range of 0° to 12° and in the range of 21° to 24°.

[0176] By correcting the out-of-reference error using the inclination correction value α and the offset correction value β, the out-of-reference error is corrected to the minus side within the range of the mechanical angle in which the reference error is on the plus side. Therefore, the out-of-reference error which is on the plus side in the range of the mechanical angle substantially the same as that of the reference error can be corrected by using the inclination correction value α and the offset correction value β, and can be brought close to 0.

[0177] The reference error is on the minus side which is smaller than 0 when the mechanical angle is in the range of 12° to 21°. Therefore, by using the inclination correction value α and the offset correction value β derived such that the reference error approaches 0, the reference error is increased and brought close to 0 when the mechanical angle is in the range of 12° to 21°. That is, the reference error is corrected to the plus side when the mechanical angle is in the range of 12° to 21°.

[0178] By correcting the out-of-reference error using the inclination correction value α and the offset correction value β, the out-of-reference error is corrected to the plus side within the range of the mechanical angle in which the reference error is on the minus side. Therefore, the out-of-reference error which is on the minus side in the range of the mechanical angle substantially the same as that of the reference error can be corrected by using the inclination correction value α and the offset correction value β, and can be brought close to 0.

[0179] Thus, when the correction rotation angle θa is calculated using Mathematical Formula 2, the out-of-reference error can be brought close to 0 without deriving the inclination correction value α and the offset correction value β for each gap G.

[0180] As described above, the signal processing unit **50** according to the present embodiment includes the GOP correction unit **54** that corrects the first conversion signal S**1** and the second

conversion signal Co, and the position calculation unit **55** that calculates the rotation angle θ before correction based on the first conversion signal Si and the second conversion signal Co corrected by the GOP correction unit **54**. The signal processing unit **50** further includes the section correction unit **56** that corrects the rotation angle θ for each of the seven sections to calculate the correction rotation angle θa. The GOP correction unit **54** corrects the first conversion signal S**1** and the second conversion signal Co such that each of the errors of the rotation angle θ approach 0 when the rotation member **20** and the substrate **30** are disposed such that the gaps G are 2 mm, 2.5 mm, 3 mm, 3.5 mm, and 4 mm. The section correction unit **56** derives the inclination correction value α and the offset correction value β in the correction function for each of the seven sections.

[0181] According to this, when the interval between the rotation member **20** and the substrate **30** is set to be the gap G having the design value, the detection error can be reduced by correcting the rotation angle θ to the correction rotation angle θa, as compared with the case where no correction is made. That is, the detection accuracy of the position detection device **1** can be improved.

[0182] Even when the interval between the rotation member **20** and the substrate **30** is set to the gap G that deviates from the design value, the detection error can be reduced by correction by using the inclination correction value α and offset correction value β when the interval is set to be the gap G having the design value.

[0183] According to the above embodiment, the following effects can be obtained.

[0184] (1) In the above embodiment, the rotation member **20** is a rotation body, and is rotatable within a rotation range of 0° to 24° which is smaller than 0° to 360°. The first reception coil **32** outputs the first voltage value V**1** corresponding to the rotation angle θ of the rotation member **20** when the rotation member **20** rotates within a rotation range of 0° to 24°. The second reception coil **33** outputs the second voltage value V**2** corresponding to the rotation angle θ of the rotation member **20** when the rotation member **20** rotates within a rotation range of 0° to 24°. The position calculation unit **55** calculates, based on the first voltage value V**1** and the second voltage value V**2** corresponding to the rotation angle θ of the rotation member **20**, the rotation angle θ of the rotation member **20** that rotates within the rotation range of 0° to 24°. The GOP correction unit **54** corrects the first conversion signal S**1** and the second conversion signal Co such that the error of the rotation angle θ within the rotation range of 0° to 24° calculated by the position calculation unit **55** approaches 0.

[0185] According to this, the angle range in which the error of the rotation angle θ is brought close to 0 is limited, and thus an absolute value of an error for each angle within the rotation range is easily reduced as compared with a case where the angle range in which the error is brought close to 0 is not limited.

[0186] (2) In the above embodiment, the reference gap is set to a center of 2 mm farthest from the reference gap among 2 mm and 2.5 mm as the two near gaps and 4 mm farthest from the reference gap among 3.5 mm and 4 mm as the two far gaps.

[0187] According to this, the error of the rotation angle θ is easily reduced as compared with a case where the reference gap is not set as described above. That is, the detection accuracy of the position detection device **1** is easily improved.

(First Modification of First Embodiment)

[0188] In the first embodiment described above, the example is described in which the position detection device **1** calculates the rotation position of the rotation member **20** that rotates within the angle range of 0° to 24°, which is smaller than 0° to 360°, but the rotation position calculated by the position detection device **1** is not limited to this. For example, the position detection device **1** may calculate the rotation position of the rotation member **20** that rotates within an angle range smaller than 0° to 360° and different from 0° to 24°. The position detection device **1** may calculate the rotation position of the rotation member **20** that rotates within an angle range of 0° to 360°. The detection body calculated by the position detection device **1** is not limited to the pedal in the case of a rotation body.

(Second Modification of First Embodiment)

[0189] In the above first embodiment, the example is described in which the GOP correction unit **54** derives the first correction term and the second correction term such that the difference between the reference error and each of the four out-of-reference errors becomes smaller with the reference error as a reference, but the present disclosure is not limited thereto.

[0190] For example, a center value, in five errors of the reference error and the four out-of-reference errors, is used as a reference value. The first correction term and the second correction term may be derived such that a difference, between the reference value and each of the reference error and the four out-of-reference errors, becomes smaller.

(Third Modification of First Embodiment)

[0191] In the first embodiment described above, the example is described in which the first correction term and the second correction term are derived by an external device different from the position detection device **1**, but the present disclosure is not limited thereto. For example, the position detection device **1** may derive the first correction term and the second correction term by the above-described derivation method. Specifically, a configuration device (for example, the GOP correction unit **54**) of the signal processing unit **50** in the position detection device **1** may derive the first correction term and the second correction term. The position detection device **1** may include a correction term derivation unit for deriving the first correction term and the second correction term.

(Fourth Modification of First Embodiment)

[0192] In the first embodiment described above, the example is described in which the GOP correction unit **54** corrects the first conversion signal S**1** and the second conversion signal Co and derives the tan θ using the corrected first conversion signal Si and second conversion signal Co and Mathematical Formula 1, but the present disclosure is not limited thereto. For example, the position calculation unit **55** may derive the tan θ by using the first conversion signal S**1** and the second conversion signal Co corrected by the GOP correction unit **54** and Mathematical Formula 1.

[0193] In such a configuration, as shown in FIG. **14**, the GOP correction unit **54** corrects the first conversion signal S**1** and the second conversion signal Co using at least one correction term among the gain correction term, the offset correction term, and the phase correction term. Information of the corrected first conversion signal Si and second conversion signal Co is output to the position calculation unit **55**.

[0194] When the information of the first conversion signal S**1** and the second conversion signal Co corrected by the GOP correction unit **54** is received, the position calculation unit **55** may calculate the tan θ based on Mathematical Formula 1 and calculate the rotation angle θ of the rotation member **20** using the calculated tan θ.

Second Embodiment

[0195] Next, a second embodiment will be described with reference to FIGS. **15** and **16**. In the present embodiment, pattern shapes of the first reception coil **32** and the second reception coil **33** are different from those of the first embodiment. The other configuration is the same as that of the first embodiment. Therefore, in the present embodiment, portions different from those of the first embodiment will be mainly described, and description of portions similar to those of the first embodiment may be omitted.

[0196] As shown in FIG. **15**, the first reception coil **32** and the second reception coil **33** according to the present embodiment are formed in an annular shape extending along the circumferential direction Dc of the substrate **30**.

[0197] The first reception coil **32** and the second reception coil **33** are disposed inside the transmission coil **31** when viewed in a direction along the normal direction. The first reception coil **32** and the second reception coil **33** are appropriately coupled to different wiring layers via the via **34** so as not to interfere with each other (that is, not to overlap in the same layer).

[0198] The first reception coil **32** is formed in a pattern shape that draws a sine curve so as to have a sine wave shape in a closed loop. In the first reception coil **32**, two adjacent wiring layers among

the wiring layers stacked in order are coupled to each other via the via **34**.

[0199] The second reception coil **33** is formed in a pattern shape that draws a cosine curve having a different phase from that of the sine curve so as to have a cosine wave shape in a closed loop. In the second reception coil **33**, two adjacent wiring layers among the wiring layers stacked in order are coupled to each other via the via **34**.

[0200] In display of the first reception coil **32** and the second reception coil **33** in FIG. **15**, in order to make it easy to understand, the first reception coils **32** and the second reception coils **33** provided over the multiple stacked wiring layers are all displayed by solid lines.

[0201] The first reception coil **32** may be formed in a pattern shape that draws a cosine curve so as to have a cosine wave shape in a closed loop. In this case, the second reception coil **33** is formed in a pattern shape that draws a sine curve having a different phase from that of the cosine curve so as to have a sine wave shape in a closed loop.

[0202] As shown in FIG. **16**, the four targets **22** to **25** of the rotation member **20** according to the present embodiment each have a fan shape in which a width in the circumferential direction Dc increases toward the outer side of the radial direction Dr. Therefore, one side end portion and the other side end portion in the circumferential direction Dc of each of the four targets **22** to **25** extend linearly along the radial direction Dr when viewed in the direction along the axial direction Da.

[0203] According to the present embodiment, the first reception coil **32** and the second reception coil **33** each form a pattern shape that draws a sine curve or a cosine curve when viewed in the direction along the normal direction. Accordingly, the first reception coil **32** outputs the first voltage value V**1** having a sine wave shape corresponding to the rotation position of the rotation member **20**. The second reception coil **33** outputs the second voltage value V**2** having a cosine wave shape corresponding to the rotation position of the rotation member **20**.

[0204] Except for what has been described above, the present embodiment is the same as the first embodiment. The present embodiment can obtain the same effects as those of the first embodiment which are obtained from the same configuration as those of the first embodiment.

Third Embodiment

[0205] Next, a third embodiment will be described with reference to FIGS. **17** and **18**. The present embodiment is different from the first embodiment in the shape and configuration of the position detection device **1**. The other configuration is the same as that of the first embodiment. Therefore, in the present embodiment, portions different from those of the first embodiment will be mainly described, and description of portions similar to those of the first embodiment may be omitted.

[0206] The position detection device **1** according to the present embodiment is capable of detecting a position of a detection body in a stroke direction. The detection body is, for example, a movable component **100** mounted on a vehicle. The position detection device **1** detects the position of the movable component **100** that is a detection body that moves along the stroke direction.

[0207] The movable component **100** according to the present embodiment straightly reciprocates in within a predetermined range along the stroke direction. As shown in FIG. **17**, the movable component **100** includes multiple magnets **110**, **120**, and **130**. The multiple magnets **110**, **120**, and **130** are disposed apart from each other along the stroke direction. The multiple magnets **110**, **120**, and **130** includes magnetic pole surfaces **111**, **121**, and **131** each having a polarity of N pole or S pole. The multiple magnets **110**, **120**, and **130** are disposed such that the magnetic pole surfaces **111**, **121**, and **131** adjacent to each other have opposite polarities to each other in N pole and S pole.

[0208] The position detection device **1** includes a case portion **10** in which a detection unit **60** to be described later is provided at a tip portion on the side of the movable component **100**. The position detection device **1** is provided with a predetermined interval between the case portion **10** and the magnetic pole surfaces **111**, **121**, and **131** of the multiple magnets **110**, **120**, and **130**. In other words, the case portion **10** faces the movable component **100** in a state of being separated from the multiple magnets **110**, **120**, and **130**. The case portion **10** is disposed such that a predetermined

interval between the case portion **10** and the magnetic pole surfaces **111**, **121**, and **131** is constant. The gap G in the present embodiment corresponds to the distance between the case portion **10** and the magnetic pole surfaces **111**, **121**, and **131**.

[0209] In the position detection device **1** according to the present embodiment, a magnetic detection method using magneto resistive elements **61** and **62** shown in FIG. **18**, in which a resistance value changes when being influenced by a magnetic field from the outside, is adopted, and the magneto resistive elements **61** and **62** are provided inside the case portion **10**. The magneto resistive elements **61** and **62** may be, for example, an anisotropic magneto resistive (AMR) element, a giant magneto resistive (GMR) element, a tunnel magneto resistive (TMR) element.

[0210] Instead of the magneto resistive elements **61** and **62**, a hall element can be adopted, and the position detection device **1** can be used as the magnetic detection method using the hall element.

[0211] As shown in FIG. **18**, the detection unit **60** includes the two magneto resistive elements **61** and **62** functioning as magnetic detection units. The two magneto resistive elements **61** and **62** acquire, as a voltage value, the change in the resistance value when being influenced by the magnetic field. Hereinafter, one of the two magneto resistive elements **61** and **62** is referred to as a first magnetic detection unit **61**, and the other is referred to as a second magnetic detection unit **62**.

[0212] The first magnetic detection unit **61** outputs the first voltage value V**1** having a sine wave shape according to a position of the movable component **100**. The second magnetic detection unit **62** outputs the second voltage value V**2** having a cosine wave shape according to the position of the movable component **100**. Therefore, in the present embodiment, the detection unit **60** functions as a signal output unit that outputs a first signal having a sine wave shape and a second signal having a cosine wave shape corresponding to the position of the movable component **100** which is a detection body. The case portion **10** functions as an arrangement unit.

[0213] Except for what has been described above, the present embodiment is the same as the first embodiment. The present embodiment can obtain the same effects as those of the first embodiment which are obtained from the same configuration as those of the first embodiment.

Fourth Embodiment

[0214] Next, a fourth embodiment will be described with reference to FIGS. **19** and **20**. The present embodiment is different from the first embodiment in the derivation method for the first correction term and the second correction term. The other configuration is the same as that of the first embodiment. Therefore, in the present embodiment, portions different from those of the first embodiment will be mainly described, and description of portions similar to those of the first embodiment may be omitted.

[0215] In the present embodiment, the first correction term and the second correction term are derived such that an error when the gap G is a design value is minimized within an angle range of 0° to 24°.

[0216] Specifically, a first gain correction term, a first offset correction term, a second gain correction term, and a second offset correction term are derived such that a reference error for each mechanical angle within the angle range of 0° to 24° approaches 0. At this time, in the present embodiment, the first gain correction term, the first offset correction term, the second gain correction term, and the second offset correction term are derived without considering an out-of-reference error for each mechanical angle within the angle range of 0° to 24°.

[0217] Accordingly, as shown in FIG. **19**, an error of the rotation angle θ for each mechanical angle when the gap G is the design value can be reduced. By using the first correction term and the second correction term derived such that the error of the rotation angle θ for each mechanical angle when the gap G is the design value is reduced, the error of the rotation angle θ for each mechanical angle when the gap G is deviated from the design value can also be reduced.

[0218] As shown in FIG. **19**, the reference error has a wave shape that changes alternately between the plus side and the minus side in the angle range of the mechanical angle of 0° to 24°.

[0219] The out-of-reference error, when the gap G is 2 mm and 2.5 mm as the near gaps, changes

in a wave shape like the reference error. The value of the out-of-reference error changes according to the change in the value of the reference error. When the mechanical angle is in the entire detection range of 0° to 24°, the value of the error is smaller than the reference error in a case of comparison at the same mechanical angle. Therefore, the out-of-reference error in the case of the near gap does not intersect the reference error, and the value of the out-of-reference error changes.

[0220] The out-of-reference error, when the gap G is 3.5 mm and 4 mm as the far gaps, changes in a wave shape like the reference error. The value of the out-of-reference error changes according to the change in the value of the reference error. When the mechanical angle is in the entire detection range of 0° to 24°, the value of the error is larger than the reference error in a case of comparison at the same mechanical angle. Therefore, the out-of-reference error in the case of the far gap does not intersect the reference error, and the value of the out-of-reference error changes.

[0221] The GOP correction unit **54** corrects the first conversion signal S**1** and the second conversion signal Co using the first gain correction term, the first offset correction term, the second gain correction term, and the second offset correction term, which are derived as described above. The GOP correction unit **54** derives the tan θ using Mathematical Formula 1. The GOP correction unit **54** transmits information of the derived tan θ to the position calculation unit **55**.

[0222] The position calculation unit **55** calculates the rotation angle θ before correction of the rotation member **20** by using the information of the tan θ derived by the GOP correction unit **54**. The section correction unit **56** calculates the correction rotation angle θa by performing the section correction by using the rotation angle θ before correction calculated by the position calculation unit **55** and Mathematical Formula 2 described in the first embodiment.

[0223] Similarly to the first embodiment, the section correction unit **56** derives the inclination correction value α and the offset correction value β such that the reference error approaches 0 for each of the seven sections in the angle range of 0° to 24 which is the detection range. The section correction unit **56** calculates the correction rotation angle θa using the rotation angle θ calculated by the position calculation unit **55**, the derived inclination correction value α, and the offset correction value β.

[0224] Accordingly, as shown in FIG. **20**, a reference error of the correction rotation angle θa can be made closer to 0 in comparison with a reference error of the rotation angle θ shown in FIG. **19**, with the gap G being 3 mm which is a design value.

[0225] It is possible to reduce a difference between the largest error and the smallest error in all the out-of-reference errors. In the present embodiment, the out-of-reference error is the largest error among all the out-of-reference errors when the gap G is 4 mm and the mechanical angle is 18°. The out-of-reference error is the smallest error among all the out-of-reference errors when the gap G is 2 mm and the mechanical angle is 16°. The difference between the largest error and the smallest error is 0.50 deg.

(Summary of Fourth Embodiment)

[0226] The fourth embodiment is configured as described above. Therefore, in summary, the following aspects are provided.

(Aspect 1)

[0227] A position detection device for detecting a position of a detection body (**20**, **100**), the position detection device comprising: [0228] a signal output unit (**32**, **33**, **61**, **62**) configured to output a first signal (V**1**) having a sine wave shape corresponding to a position of the detection body, and a second signal (V**2**) different in phase from the first signal and having a cosine wave shape corresponding to the position of the detection body; [0229] an arrangement unit (**30**, **10**) provided with the signal output unit and facing the detection body in a state of being spaced apart from the detection body; and [0230] a signal processing unit (**50**) configured to calculate, based on the first signal and the second signal output from the signal output unit, a detection body position which is a position of the detection body when the detection body is displaced in a predetermined detection range, wherein [0231] the signal processing unit includes [0232] a signal correction unit

(**54**) configured to correct the first signal and the second signal, [0233] a position calculation unit (**55**) configured to calculate a pre-correction detection body position based on the first signal and the second signal corrected by the signal correction unit, the pre-correction detection body position being the detection body position before correction, and [0234] a section correction unit (**56**) configured to [0235] calculate a correction function based on an error of the pre-correction detection body position calculated by the position calculation unit, and [0236] correct the pre-correction detection body position calculated by the position calculation unit for each of sections of the detection range using the correction function, [0237] an interval between the detection body and the arrangement unit in a facing direction in which the detection body and the arrangement unit face each other is defined as a gap (G), [0238] the gap that serves as a reference is defined as a reference gap, [0239] the gap smaller than the reference gap is defined as a near gap, [0240] the gap larger than the reference gap is defined as a far gap, [0241] the signal correction unit is configured to bring each of errors of the pre-correction detection body position occurring when the gap is at the near gap or/and the far gap to approach 0 by correcting the first signal and the second signal such that an error of the pre-correction detection body position occurring when the gap is at the reference gap approaches 0, and [0242] the section correction unit is configured to derive a correction value used in the correction function for each of the sections.

Fifth Embodiment

[0243] Next, a fifth embodiment will be described with reference to FIG. **21**. The present embodiment is different from the first embodiment in that the transmission coil **31** is not provided on the substrate **30**. The other configuration is the same as that of the first embodiment. Therefore, in the present embodiment, portions different from those of the first embodiment will be mainly described, and description of portions similar to those of the first embodiment may be omitted.

[0244] As shown in FIG. **21**, unlike the first embodiment, the wiring pattern of the transmission coil **31** is not provided on the substrate **30** according to the present embodiment. As described in the first embodiment, the first reception coil **32** and the second reception coil **33** mainly have a spiral shape. In the present embodiment, the first reception coil **32** and the second reception coil **33** provided on the substrate **30** function as inductance elements having a predetermined inductance when an alternating current is applied from the oscillation unit **51**. In FIG. **21**, illustration of the coupling wiring **35** is omitted.

[0245] When such a substrate **30** does not have the transmission coil **31**, an eddy current generated in the rotation member **20** changes according to the rotation position of the rotation member **20**. For example, when the rotation member **20** rotates and the rotation position of the first target **22** facing the first reception coil **32** and the second reception coil **33** changes, an eddy current generated in the first target **22** changes.

[0246] Inductances of the first reception coil **32** and the second reception coil **33** facing the first target **22** change. Such a change in the inductance can be detected by a detection circuit (not shown). The detection circuit is formed by a resonance circuit including, for example, a coil and a capacitor. In other words, the first reception coil **32** outputs the change in the inductance of the first reception coil **32** that changes according to the rotation position of the rotation member **20**. The second reception coil **33** outputs the change in the inductance of the second reception coil **33** that changes according to the rotation position of the rotation member **20**.

[0247] The change in the inductance of each of the first reception coil **32** and the second reception coil **33** detected by the detection circuit periodically changes according to the rotation position of the rotation member **20**. The detection circuit outputs, to the AD conversion unit **53**, information on the change in the inductance of each of the first reception coil **32** and the second reception coil **33** to be detected. The information on the change in the inductance of the first reception coil **32** output by the detection circuit corresponds to the first voltage value V**1** in the first embodiment. The information on the change in the inductance of the second reception coil **33** output by the detection circuit corresponds to the second voltage value V**2** in the first embodiment.

[0248] Except for what has been described above, the present embodiment is the same as the first embodiment. The present embodiment can obtain the same effects as those of the first embodiment which are obtained from the same configuration as those of the first embodiment.

Other Embodiments

[0249] Although the representative embodiments of the present disclosure are described above, the present disclosure is not limited to the embodiments described above, and various modifications can be made, for example, as follows.

[0250] In the embodiments described above, the reference gap is 3 mm, which is the design value, and the gap G deviating from the design value is 2 mm, 2.5 mm, 3.5 mm, and 4 mm. The example is described in which the reference gap is 3 mm as a center between 2 mm and 4 mm, which are farthest from the reference gap, but the present disclosure is not limited thereto.

[0251] The reference gap is not limited to 3 mm, and may be changed as appropriate. The gap G deviated from the design value may include a gap having a size smaller than 2 mm, or may include a gap larger than 4 mm. The gap G deviated from the design value may include one or three or more near gaps. The gap G deviated from the design value may include one or three or more far gaps. The reference gap may be set to a size deviated from a center between a size that is farthest from the reference gap among multiple near gaps and a size that is farthest from the reference gap among multiple far gaps.

[0252] In the embodiments described above, the example is described in which the gain correction term and the offset correction term among the gain correction term, the offset correction term, and the phase correction term for each of the first conversion signal S**1** and the second conversion signal Co are derived by the GOP correction unit **54**, but the present disclosure is not limited thereto.

[0253] For example, the GOP correction unit **54** may derive one of the gain correction term, the offset correction term, and the phase correction term for each of the first conversion signal S**1** and the second conversion signal Co. Specifically, the GOP correction unit **54** may derive, for example, only one correction term among the gain correction term, the offset correction term, and the phase correction term for each of the first conversion signal S**1** and the second conversion signal Co. The GOP correction unit **54** may derive any two correction terms among the gain correction term, the offset correction term, and the phase correction term for each of the first conversion signal S**1** and the second conversion signal Co. The GOP correction unit **54** may derive all of the gain correction term, the offset correction term, and the phase correction term for each of the first conversion signal S**1** and the second conversion signal Co.

[0254] In the embodiments described above, it is needless to say that the elements forming the embodiments are not necessarily essential except in a case where those elements are clearly indicated to be essential in particular, a case where those elements are considered to be obviously essential in principle, and the like.

[0255] In the embodiments described above, when referring to the number, the numerical value, the amount, the range, and the like of the components of the embodiment, the present disclosure is not limited to a specific number of components of the embodiments, except in a case of being particularly noted as being essential, a case of being limited to a specific number in principle, and the like.

[0256] In the embodiments described above, when referring to the shape, the positional relationship, and the like of the component and the like, the present disclosure is not limited to the shape, the positional relationship, and the like, except in a case of being particularly noted, a case of being limited to a specific shape, a specific positional relationship in principle, and the like.

[0257] The signal processing circuit **40** and the method therefor of the present disclosure may be implemented by a dedicated computer provided by including a processor and a memory that are programmed to execute one or more functions embodied by a computer program. The signal processing circuit **40** and the method therefor of the present disclosure may be implemented by a

dedicated computer provided by including a processor with one or more dedicated hardware logic circuits. The signal processing circuit **40** and the method therefor of the present disclosure may be implemented by one or more dedicated computers, each including a combination of a processor and a memory that are programmed to execute one or more functions and a processor formed of one or more hardware logic circuits. The computer program may be stored in a computer-readable non-transient tangible recording medium, as an instruction executed by a computer.

[0258] While the present disclosure has been described with reference to embodiments thereof, it is to be understood that the disclosure is not limited to the embodiments and constructions. To the contrary, the present disclosure is intended to cover various modification and equivalent arrangements. In addition, while the various elements are shown in various combinations and configurations, which are exemplary, other combinations and configurations, including more, less or only a single element, are also within the spirit and scope of the present disclosure.

Claims

1. A position detection device for detecting a position of a detection body, the position detection device comprising: a signal output unit configured to output a first signal having a sine wave shape corresponding to a position of the detection body, and a second signal different in phase from the first signal and having a cosine wave shape corresponding to the position of the detection body; an arrangement unit provided with the signal output unit and facing the detection body in a state of being spaced apart from the detection body; and a signal processor configured to calculate, based on the first signal and the second signal, a detection body position which is a position of the detection body when the detection body is displaced in a predetermined detection range, wherein the signal processor is configured to correct the first signal and the second signal, calculate a pre-correction detection body position based on the corrected first signal and second signal, the pre-correction detection body position being the detection body position before correction, calculate a correction function based on an error of the calculated pre-correction detection body position, and correct the pre-correction detection body position calculated for each of sections of the detection range using the correction function, an interval between the detection body and the arrangement unit in a facing direction in which the detection body and the arrangement unit face each other is defined as a gap, the gap that serves as a reference is defined as a reference gap, the gap smaller than the reference gap is defined as a near gap, the gap larger than the reference gap is defined as a far gap, and the signal processor is configured to correct the first signal and the second signal such that each of errors of the pre-correction detection body position approach 0, the errors including errors occurring when the gap is at the reference gap, one or different near gaps, and one or different far gaps, and derive a correction value used in the correction function for each of the sections.

2. A position detection device for detecting a position of a detection body, the position detection device comprising: a signal output unit configured to output a first signal having a sine wave shape corresponding to a position of the detection body, and a second signal different in phase from the first signal and having a cosine wave shape corresponding to the position of the detection body; an arrangement unit provided with the signal output unit and facing the detection body in a state of being spaced apart from the detection body; and a signal processing unit configured to calculate, based on the first signal and the second signal, a detection body position which is a position of the detection body when the detection body is displaced in a predetermined detection range, wherein the signal processing unit includes a signal correction unit configured to correct the first signal and the second signal, a position calculation unit configured to calculate a pre-correction detection body position based on the first signal and the second signal corrected by the signal correction unit, the pre-correction detection body position being the detection body position before correction, and a section correction unit configured to calculate a correction function based on an error of the pre-

correction detection body position calculated by the position calculation unit, and correct the pre-correction detection body position calculated by the position calculation unit for each of sections of the detection range using the correction function, an interval between the detection body and the arrangement unit in a facing direction in which the detection body and the arrangement unit face each other is defined as a gap, the gap that serves as a reference is defined as a reference gap, the gap smaller than the reference gap is defined as a near gap, the gap larger than the reference gap is defined as a far gap, the signal correction unit is configured to correct the first signal and the second signal such that each of errors of the pre-correction detection body position approach 0, the errors including errors occurring when the gap is at the reference gap, one or different near gaps, and one or different far gaps, and the section correction unit is configured to derive a correction value used in the correction function for each of the sections.

3. The position detection device according to claim 2, wherein the detection body is a rotation body rotatable within a predetermined rotation range smaller than a range from 0° to 360°, the signal output unit is configured to output the first signal and the second signal according to a rotation angle of the detection body when the detection body rotates within the predetermined rotation range, the signal correction unit is configured to correct the first signal and the second signal such that the error of the pre-correction detection body position within the predetermined rotation range calculated by the position calculation unit approaches 0, and the position calculation unit is configured to calculate the pre-correction detection body position within the predetermined rotation range based on the first signal and the second signal corrected by the signal correction unit.

4. The position detection device according to claim 2, wherein the reference gap is set to be a midpoint between a near gap farthest from the reference gap among the one or different near gaps and a far gap farthest from the reference gap among the one or different far gaps.

5. The position detection device according to claim 2, wherein the signal correction unit is configured to correct at least one of a phase, a gain, and an offset of the first signal, and correct at least one of a phase, a gain, and an offset of the second signal.

6. The position detection device according to claim 5, wherein the signal correction unit is configured to correct the offset of the first signal and the offset of the second signal such that a difference between the error of the pre-correction detection body position occurring when the gap is at the reference gap and the error of the pre-correction detection body position occurring when the gap is at the far gap approaches 0.

7. The position detection device according to claim 5, wherein the signal processing unit is configured to calculate, based on the first signal and the second signal, the detection body position by calculating an arc tangent function and performing arc tangent conversion, and the signal correction unit is configured to correct the offset of the first signal and the offset of the second signal such that a primary component obtained by the signal processing unit performing the arc tangent conversion on the first signal and the second signal when the gap is at the far gap approaches a primary component obtained by the signal processing unit performing the arc tangent conversion on the first signal and the second signal when the gap is at the near gap.

8. The position detection device according to claim 7, wherein the offset of the first signal includes a first static offset which is an offset component independent of a change in an amplitude of the first signal, and a first variable offset which is an offset component which changes according to the change in the amplitude of the first signal, the offset of the second signal includes a second static offset which is an offset component independent of a change in an amplitude of the second signal, and a second variable offset which is an offset component which changes according to the change in the amplitude of the second signal, the signal correction unit is configured to adjust the first static offset such that a relationship between an amount of change in the amplitude of the first signal and an amount of change in the offset of the first signal based on the amount of change in the amplitude of the first signal becomes proportional, and adjust the second static offset such that a relationship between an amount of change in the amplitude of the second signal and an amount of

change in the offset of the second signal based on the amount of change in the amplitude of the second signal becomes proportional, and the section correction unit is configured to correct the pre-correction detection body position calculated by the position calculation unit for each of the sections such that the primary component included in the detection body position calculated by performing the arc tangent conversion on the first signal and the second signal is removed.

9. The position detection device according to claim 2, wherein the arrangement unit is a substrate, the signal output unit is provided on the substrate and includes a transmission coil, a first reception coil and a second reception coil, the first reception coil and the second reception coil are configured to be inductively coupled with the transmission coil by electromagnetic induction caused by energization to the transmission coil, the first reception coil is configured to output a first voltage value as the first signal corresponding to the detection body position, the first voltage value changing due to an influence of an eddy current induced in the detection body by the electromagnetic induction from the energized transmission coil, the second reception coil is configured to output a second voltage value as the second signal corresponding to the position of the detection body, the second voltage value changing due to the influence of the eddy current induced in the detection body by the electromagnetic induction from the energized transmission coil, and the signal processing unit is configured to calculate the detection body position based on the first voltage value and the second voltage value.

10. The position detection device according to claim 2, wherein the arrangement unit is a substrate, the signal output unit is provided on the substrate and includes a first reception coil and a second reception coil which are configured to be changed in inductance according to the detection body position, the first reception coil is configured to output the first signal as an inductance change of the first reception coil that changes according to the detection body position, the second reception coil is configured to output the second signal as an inductance change of the second reception coil that changes according to the detection body position, and the signal processing unit is configured to calculate the detection body position based on the inductance change of the first reception coil and the inductance change of the second reception coil.

11. The position detection device according to claim 9, wherein the first reception coil and the second reception coil include a portion having a spiral pattern shape.

12. The position detection device according to claim 9, wherein one of the first reception coil and the second reception coil has a shape that follows a sine curve pattern, and the other of the first reception coil and the second reception coil has a shape that follows a cosine curve pattern different in phase from the sine curve pattern.

13. The position detection device according to claim 2, wherein the detection body has a magnet, and the signal output unit includes a first magnetic detection unit and a second magnetic detection unit which are configured to output the first signal and the second signal, respectively, based on a change in a magnetic field received from the magnet that changes according to the detection body position.